

PRODUCT CATALOG 2022

WWW.ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/

ELVEFLOW PRODUCT CATALOG 2022 REF: PC22-0629

STATE OF THE ART microfluidic instrumentation for all

Elveflow is an Elvexys brand. We build premium flow handling instruments since 2012. We are proud to have provided **more than 2,000 systems** so far to both academics and industrial users.

Our product line is built around **the best seller OB1 flow controller** and includes everything for accurate liquid handling. All our instruments can be controlled simultaneously using our **software** and **Software Development Kits** allowing for a full automation of your system.

Our instruments are **modular, upgradable** and come in a **standard** or **OEM** version.

CONTACT:

+33(0).184.163.807
contact@elveflow.com
www.elveflow.com

ADDRESS:

172 Rue de Charonne,
75011 Paris
France

PRODUCTS



FLOW CONTROL SYSTEMS



OB1 MK3+
MULTI CHANNEL PRESSURE & VACUUM CONTROLLER p.05



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OEM & CUSTOM



OEM & CUSTOM

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ESI - FREE SOFTWARE

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PACKS & ACCESSORIES



PACKS

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ACCESSORIES

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ELVEFLOW OVERVIEW

Elveflow focuses on the development of high performance, **plug and play flow control systems** perfect for microfluidic research. We provide the only microfluidic flow control systems using **Piezo technology** allowing blazing fast flow changes in your microdevice.

contact@elveflow.com

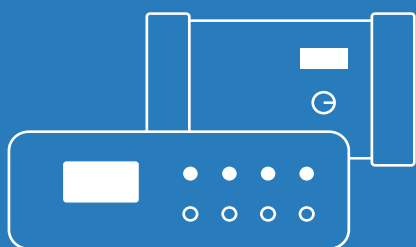
MULTIDISCIPLINARY EXPERTS HERE TO HELP YOU

Our **multidisciplinary team** provides a wide range of development and services. Our management is composed of talented engineers, physicists and biologists in microfluidics totaling more than 70 peer reviewed publications, 400 citations and 10 microfluidic patents.

ELVEFLOW an **ELVESYS** brand

**MICROFLUIDICS
INNOVATION
CENTER** +

MICROFLUIDIC POETRY,
an uncommon, conceptual and sensitive vision of the
microfluidic field, on the blurring border between art & science.
<https://www.elveflow.com/fr/actualites/microfluidics-reviews-and-tutorials/microfluidic-poetry-unique-imaginative-sensitive-vision-microfluidics-field>



PRODUCTS

FLOW CONTROL SYSTEMS



OB1 MK3+

MULTI CHANNEL PRESSURE & VACUUM CONTROLLER

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/FLOW-CONTROL-SYSTEM/PRESSURE-CONTROLLER/


★ BEST SELLER

**DON'T LET YOUR PUMP
LIMIT YOUR RESEARCH**
BEST RESPONSIVENESS
AND ACCURACY ON THE
MARKET

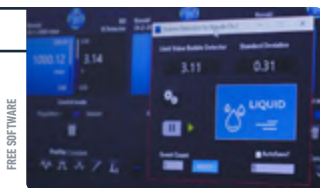


The OB1 MK3+ is a **high performance** microfluidic pressure and flow controller. Customize your unit: pick the number of channels you like and **choose for each of them the pressure and vacuum ranges** among the 5 options available.

✓ MODULAR

✓ UPGRADABLE

✓ SOFTWARE INCLUDED



UNIQUE PERFORMANCES

- > Pressure stability **0.005 % FS**
- > Response time **9 ms**
- > Pressure resolution **0.003 % FS**
- > Settling time **down to 35 ms**



**CUTTING EDGE
PIEZO CONTROL
FOR MICROFLUIDICS**

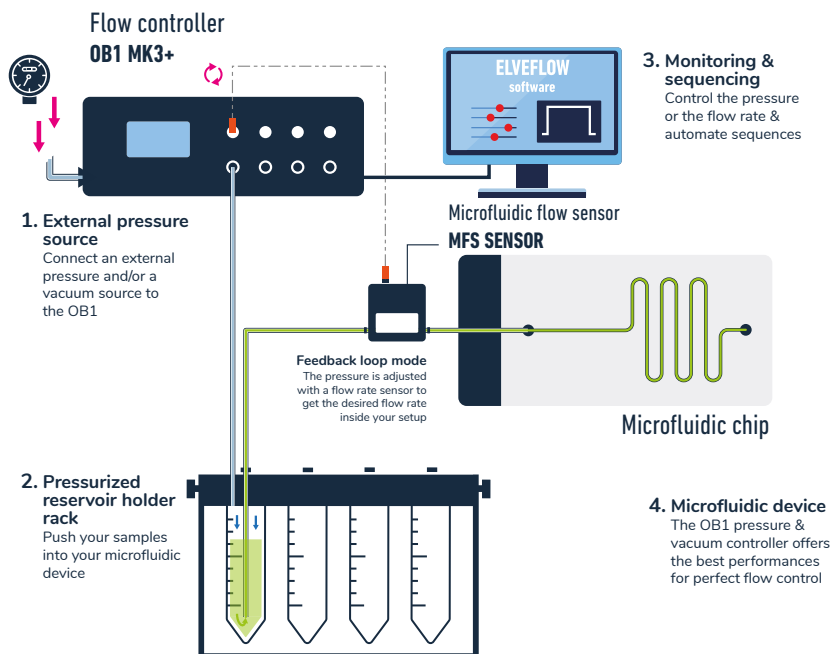
APPLICATIONS

- > Digital microfluidics
- > Flow chemistry & polymer synthesis
- > Cell culture: cell perfusion, sequential injection
- > Droplet-sequencing: RNA sequencing
- > Organ on chip
- > Enhanced oil recovery
- > Lab on a chip



**CHOOSE FROM 1 TO 4
CHANNELS, AND MORE...**

Get a one-channel today and
add more channels later



> To **control flow rate or pressure** at any given point of your circuit, you can perform a **feedback loop** with the flow rate. The same can be done with pressure using a pressure sensor.

- 1 External pressure source**
Connect a pressure and/or a vacuum source to your OB1 (required).
Example: Gas cylinder, lab pressure line, compressor ([see more p.40](#))
- 2 Sample**
Depending on your choice, the liquids can be pulled into the reservoir or be pushed from there since the OB1 can use pressure or vacuum within the same channel.
- 3 Monitoring & sequencing**
Automate pressure and flow control using the Elveflow software on your computer.
- 4 Microfluidic device**
The OB1's pressure & vacuum features offer precise sample handling, and provide full control over the injection.

FEATURES & BENEFITS



• Short settling time

Operate blazing fast changes in any microdevice with our Piezo technology

• Highest flow stability

Ensure superior flow performance over a large flow range, with pressure stability down to 10 μ bar

• Accurate flow control

Input a flow value into the software. Flow regulation down to 7.5 nL/min



• Software automation

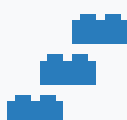
Control all instruments through a single dashboard. Powerful script module to automate control and injection over days

• Create your own program

Software Development Kits (C++, Python, MATLAB® and LabVIEW® libraries)

• Enhanced data saving

Up to 10 ms sampling rate to take out the best of your results



• Easy to install and use

Start out of the box and set everything up within minutes

• Customizable

Choose from any number of channels among the five pressure ranges available

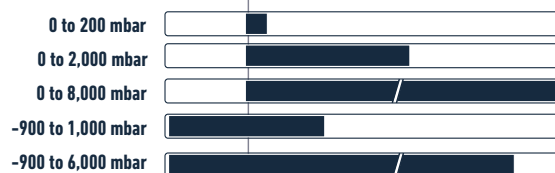
• Upgradable

Get a one-channel today and add more channels later

PRESSURE RANGES



**FOR EACH CHANNEL:
5 PRESSURE RANGES AVAILABLE**

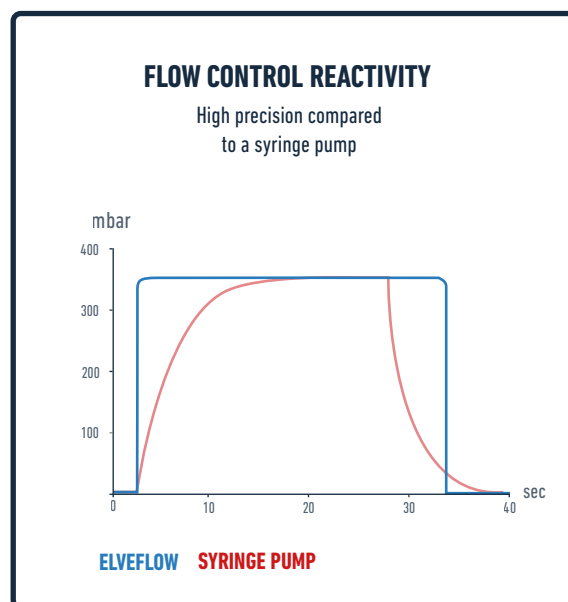
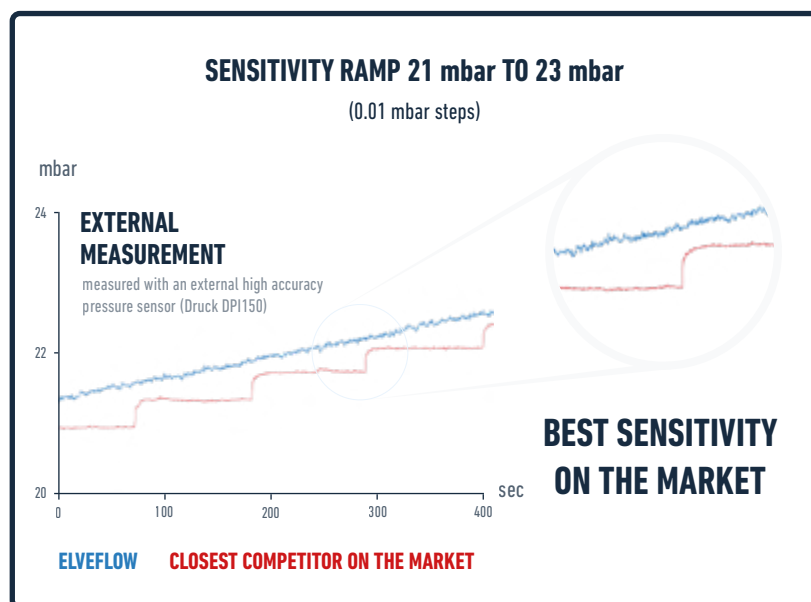


OB1 MK3+ CHANNEL PRESSURE RANGE	0 to 200 mbar ⁽¹⁾ (0 to 2.9 psi)	0 to 2,000 mbar ⁽¹⁾ (0 to 29 psi)	0 to 8,000 mbar ⁽¹⁾ (0 to 116 psi)	-900 to 1,000 mbar ⁽¹⁾ (-13 to 14.5 psi)	-900 to 6,000 mbar ⁽¹⁾ (-13 to 87 psi)
Pressure stability ⁽²⁾	0.005 % FS 10 µbar (0.00014 psi)	0.005 % FS 100 µbar (0.0014 psi)	0.006% FS 500 µbar (0.007 psi)	-900 to 500 mbar:	-900 to 2,000 mbar:
				0.005 % FS 100 µbar (0.0014 psi)	0.005 % FS 350 µbar (0.05 psi)
				500 to 1,000 mbar:	2,000 to 6,000 mbar:
				0.007 % FS 150 µbar (0.0021 psi)	0.007 % FS 525 µbar (0.076 psi)
Response time ⁽³⁾	down to 9 ms				
Settling time ⁽⁴⁾	down to 35 ms				
Minimum pressure increment	0.003 % FS 6.1 µbar - 0,000085 ps	0.003 % FS 56 µbar - 0,00085 psi	0.003 % FS 240 µbar - 0,0035 psi	0.0032 % FS 61 µbar - 0,00085 psi	0.003 % FS 210 µbar - 0.003 psi
Input pressure	1.5 bar - 10 bar non corrosive, non explosive, dry and oil-free gases, e.g. air, argon, N2, CO2, ...				
Input vacuum ⁽⁵⁾	/			any value from 0 to -1 bar	
Liquid compatibility	no liquid should enter the OB1 any aqueous or organic solvent, oil or biological sample solution can be propelled				

Non-contractual information, may be changed without notice.

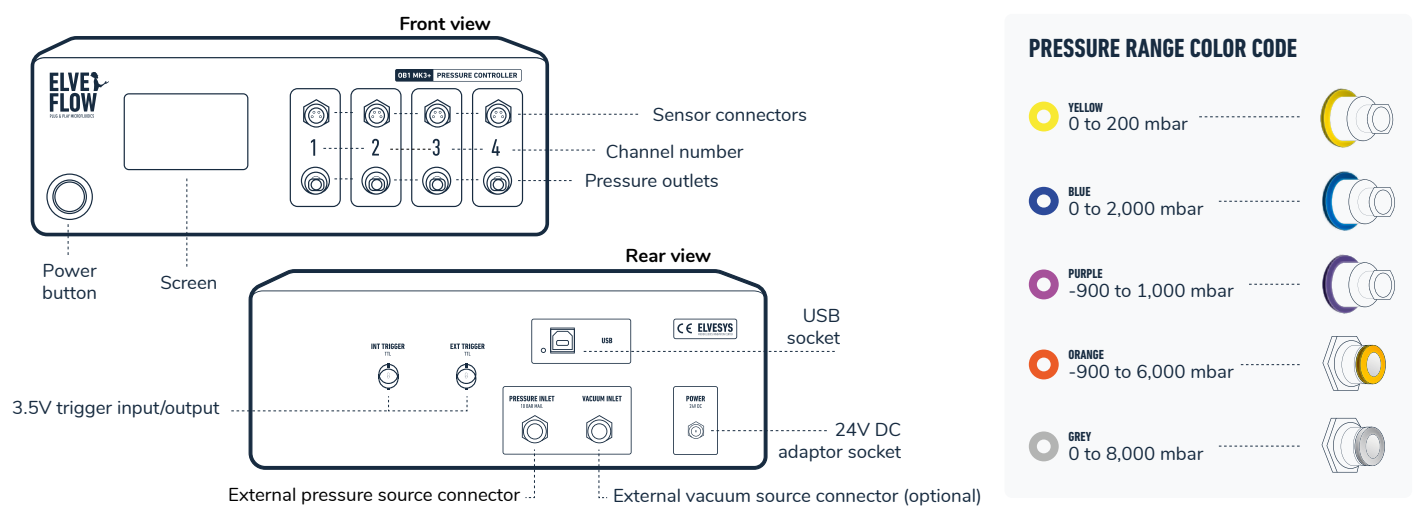
POWER CONSUMPTION (maximum): 12 W **CASE DIMENSIONS** (length x width x height): 240 x 223 x 80 mm **WEIGHT**: 1.7 kg to 3.04 kg (3.1 Kg) **TTL TRIGGER**: input 5V / output 3,3V

(1) Max pressure value might vary by +/- 2.5% (2) Pressure stability (standard deviation) measured over the full pressure range with an external high accuracy pressure sensor (Paroscientific MODEL 745) (3) Depending on your computer's operating system (4) Volume dependent - Measurement done on 12 mL reservoir for a set point from 100 to 200 mbar (5) The vacuum channels can be used without vacuum source if only positive pressures are desired.



They trust Elveflow's performances and quality:





PRODUCTS & SERVICES

ELEMENTS PROVIDED BY ELVEFLOW	INCLUDED	OPTIONAL
Software & libraries Control all Elveflow instruments with the same smart interface	•	
Starter pack kit A complete set of accessories fitted for the OB1 flow generator		•
Reservoirs Gas tight reservoirs with ergonomic fluidic connection		•
Flow sensors A line of sensors to monitor very low liquid flow rates		•
Compressor A safe & secure pressure source for the OB1 pressure controller		•
Service The Elveflow expertise & support to offer you individually tailored solutions	•	

SOFTWARE FEATURES ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/FLOW-CONTROL-SYSTEM/ELVEFLOW-SOFTWARE/

- > Pressure & flow rate **visualization** and **recording**
- > **Programming & automation** of complex sequences
- > Easy alternative instrument control through the provided **C++**, **Python**, **MATLAB®** and **LabVIEW®** libraries



National Instrument is our technological partner for embedded electronics



More information:



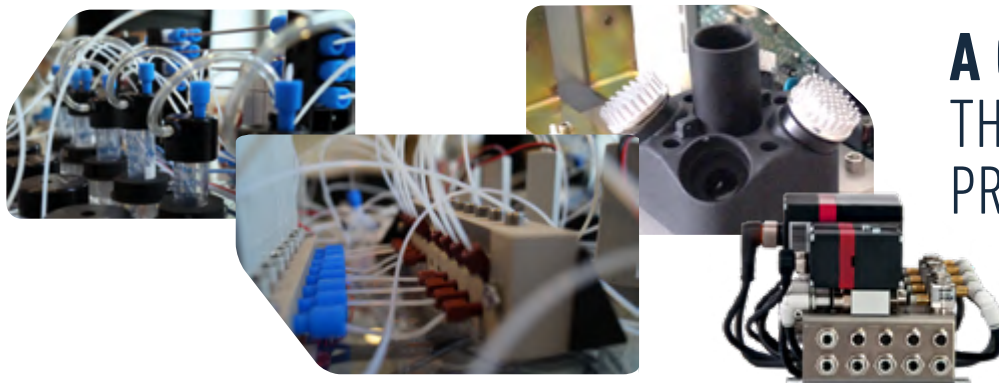
ESI - FREE SOFTWARE

ELVEFLOW SMART INTERFACE - ALL INSTRUMENTS

P.37

OEM - ORIGINAL EQUIPMENT MANUFACTURER CUSTOM FLUIDIC SYSTEMS

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/OEM-CUSTOM-FLUIDIC-SYSTEMS/



A CUSTOM SOLUTION THAT FITS YOUR PROJECT PERFECTLY

Elveflow provides a **comprehensive line of OEM fluidic components** that can be integrated into your products. Our OEM components allow a seamless integration thanks to their **small footprint** and **easy interfacing**. A **simple serial USB connection** allows interfacing through our API, the native in/out triggers provide optimum interactions and we use standard fittings for pneumatic and fluidic connections.

We provide a dedicated software with all fluidic OEM products, as well as libraries for a **customized software development** (C++, Python, MATLAB® and LabVIEW® libraries).

SERVICES

- > Personalized expert advice for our clients and partners
- > Creation of technical specifications
- > Risk management and analysis
- > Development and production of mechanics, electronics and software
- > Prototyping
- > Beta testing, troubleshooting and continuous improvement
- > Production, from limited series to large scale
- > Maintenance, support and training
- > Upgrades of your systems

WHY CHOOSE US AS YOUR OEM PARTNER?

- > **A receptive and efficient partner** – We are well aware of the importance of keeping up with your fast-changing market.
- > **A soft intellectual property policy** – We believe that intellectual property should never be an obstacle to innovation.
- > **A trusted manufacturer** – High profile companies already trust us for their scientific instruments. Why not you?
- > **A proven track record** – Our team carried out successfully several projects taking into account challenging constraints to end up with the best solutions for our partners.

COBALT AUTONOMOUS MICROFLUIDIC PUMP

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-FLOW-CONTROL-SYSTEMS/AUTONOMOUS-VACUUM-PRESSURE-PUMPS/



STANDALONE PRESSURE-DRIVEN FLOW CONTROLLER



The Elveflow® Cobalt autonomous microfluidic pump provides easy access to the most stable and accurate pressure and flow control technology. Equipped with its own pressure (and vacuum) source, it does not require an external pressure supply. Also, thanks to its embedded software, it can be controlled with or without a computer.

✓ **MOST STABLE FLOW AND PRESSURE CONTROL**

✓ **INTUITIVE USER INTERFACE**

✓ **PORTABLE AND COMPACT**

UNIQUE PERFORMANCES*

Cobalt generates powerful flow control when paired with a MFS flow sensor from our product line:

- > Flow rate range from 200nL/min to 5mL/min
- > Repeatability down to 3.5 nL/min
- > Accuracy down to 20 nL/min

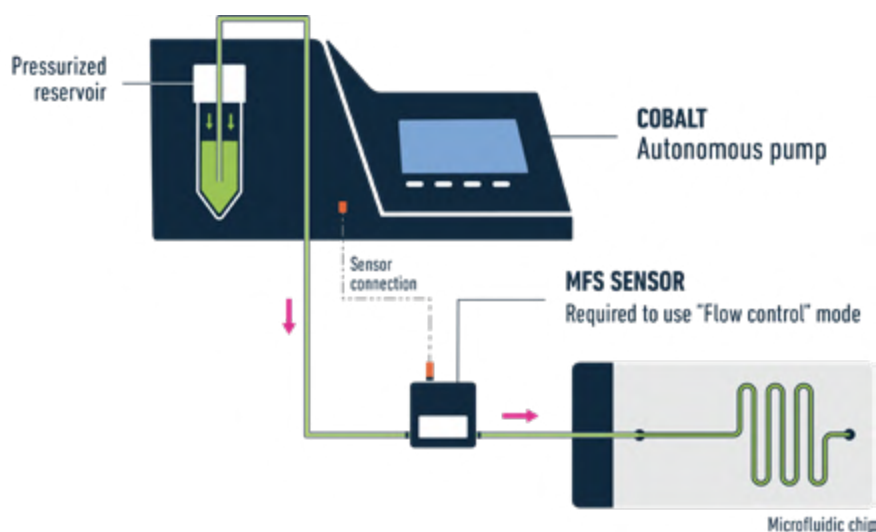
Available in two versions:

- > pushing only: pressure range 0/2000 mbar
- > push & pull: vacuum and pressure range -900/1000 mbar

* All the values given for water.

APPLICATIONS

- > Lab-on-chip development
- > Bench test or characterisation (chips, sensors, filters, etc)
- > Mechanobiology (cell confinement, tissue engineering, etc)
- > Cell perfusion



> **Plug it to a power source:**

All you have to do is to turn on your Cobalt. The pressure source is inside.

> **Connect the reservoir:**

No more pneumatic tubing needed. You only have to plug your reservoir to the instrument.

> **Program and run your experiment:**

Automate pressure and flow control using the Elveflow embedded software, no computer needed!

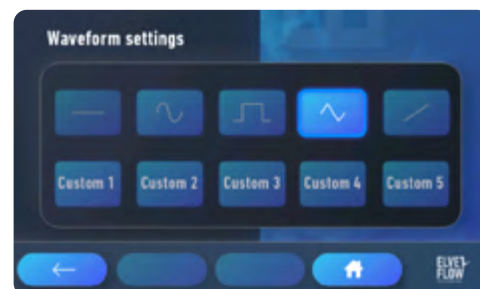
Choose between two Cobalt versions; both allow either gas or flow control when paired with a flow sensor.

> 0 to 2000 mbar positive pressure control.

> -700 to 1000 mbar dual vacuum & pressure control.

The **Cobalt technology** made state-of-the-art microfluidics accessible, autonomous, and user-friendly.

COBALT EMBEDDED SOFTWARE



Cobalt's intuitive embedded software can be fully controlled without the need of external software. Its user-friendly interface contains a knob button for easy setting modifications.



OPTIONAL
COBALT COMPUTER SOFTWARE

The Cobalt® computer software allows you to control advanced tasks - such as real-time creation, monitoring, and modifications of complex pressure and flow rate profiles - via computer using a USB connection.

	COBALT	COBALT DUAL
PNEUMATICS		
Flow control	Push	Push & pull
Pressure range ⁽¹⁾	0 to 2000 mbar (0 to 29 psi)	-700 to 1000 mbar (-10 to 14 psi)
Minimum pressure increment step	Cobalt Embedded Software (1 mbar) Computer software (0.1 mbar)	
Pressure stability ⁽²⁾	0.1 mbar	
Electronic response time	Cobalt Embedded Software: down to 10 ms Computer software: down to 100 ms ⁽³⁾	
Settling time ⁽⁴⁾	Down to 75 ms	Down to 105 ms
Pressure Source	No pressure source needed (integrated)	No pressure & vacuum source needed (integrated)
FLOW CONTROL		
Flow sensor compatibility	Possible to pair 1 flow sensor from the Elveflow MFS series (MFS2, 3, 4, 5)	
Flow rates ⁽⁵⁾	MFS2: 0 to 7 µL/min MFS3: 0 to 80 µL/min MFS4: 0 to 1000 µL/min MFS5: 0 to 5000µL/min	
Minimum flow rate increment	MFS2: 3.5 nL/min MFS3: 8 nL/min MFS4: 0.2 µL/min MFS5: 1 µL/min	
Flow sensor calibration	User-friendly automated sensor calibration module ⁽⁶⁾	
Liquid compatibility	Non contact pump. Any aqueous or organic solvent, oil, or biological sample solution. Recalibration required for non aqueous solutions at the bottom of the game	
CONTROL & MONITORING		
User interfaces	Cobalt Embedded Software Cobalt computer software (Windows) on PC	
Cobalt computer software added functionalities	Custom profile: design, upload, download Recording data: download	
Record frequency range	Cobalt Embedded Software: 1-5-10Hz Computer software: 0-100Hz	
Maximum recording time	Cobalt Embedded Software: up to 6000 sec depending on recording frequency Computer software: unlimited	
OTHER		
Power consumption	36 W (100 V to 240 V - 50 Hz to 60 Hz)	
Case dimensions	328 x 235 x 168 mm (l x w x h)	
Weight	3.3 kg	4.1 kg
Output connectors	Quick Connect	

⁽¹⁾ Max pressure value might vary by +/- 2.5%.

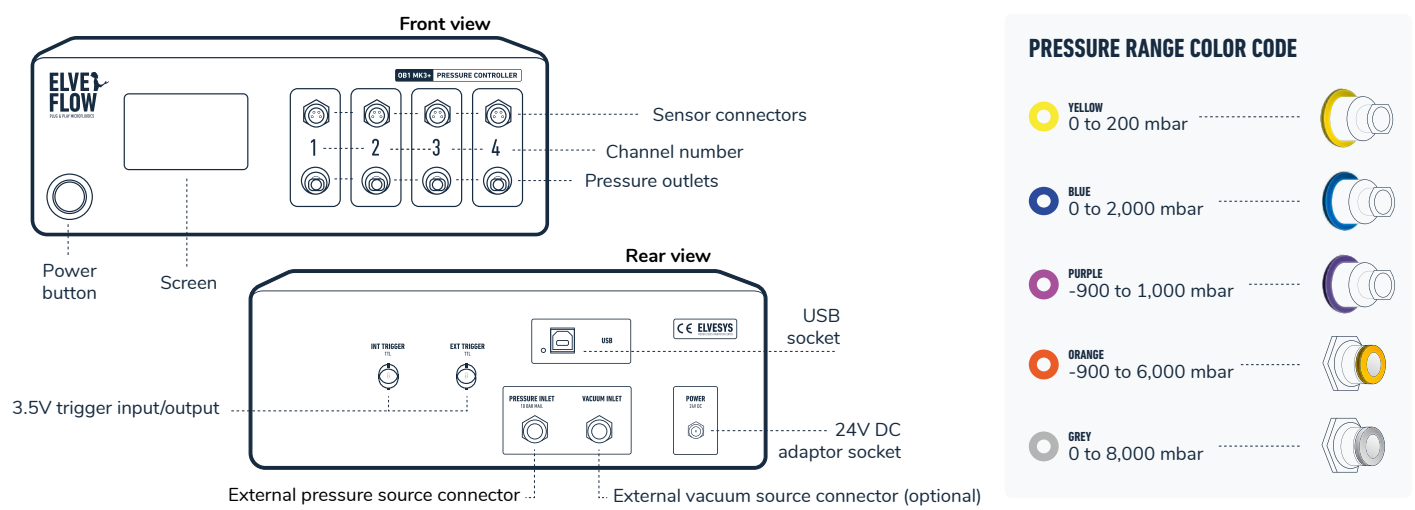
⁽²⁾ Pressure stability (standard deviation) is measured over 60s, 1 minute after the setpoint is reached.

⁽³⁾ Depending on your computer's operating system.

⁽⁴⁾ Volume dependent – Measurement done on 12 mL reservoir for a set point from 100 to 200 mbar.

⁽⁵⁾ Indicative, please refer to the MFS documentation for detailed specifications.

⁽⁶⁾ For aqueous solutions only.



MUX DISTRIB

12-WAY BIDIRECTIONAL VALVE

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-FLOW-CONTROL-SYSTEMS/MUX-DISTRIB/

Included in our

SEQUENTIAL FLUID INJECTION PACK

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-APPLICATION-PACKS/SEQUENTIAL-FLUID-INJECTION-PACK/



A ROTARY VALVE DESIGNED TO EASILY EXECUTE FAST MEDIUM SWITCHES



The Sequential Injection Valve is a **bidirectional 13-port/12 way** which can be used as a selector to inject sequentially one liquid sample into **twelve different lines** or twelve liquid samples into one line.

✓ **INJECTION OF UP TO 12 LIQUIDS**

✓ **NO CROSS CONTAMINATION**

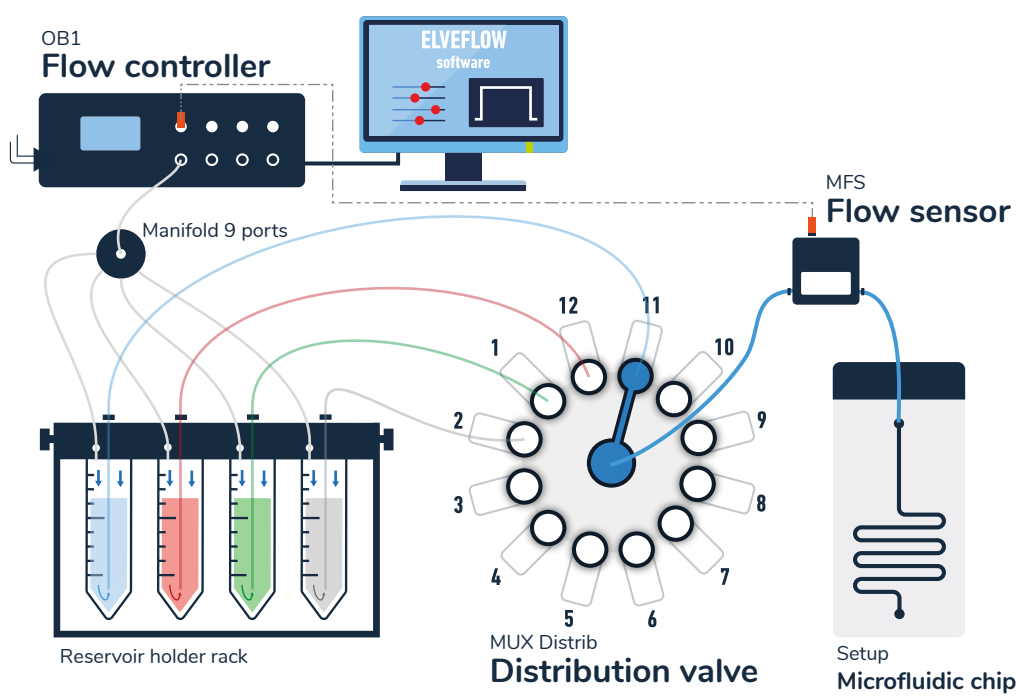
UNIQUE PERFORMANCES

- > Typical mechanical response time for port-to-port movement **156 ms**
- > Easy setup: standard **¼-28 fluidic fittings**
- > Lowest internal volume: **3.5 µL**
- > **High chemical compatibility** (wetted materials: PCTFE, PTFE)
- > Possibility to chose the **sense of rotation**

APPLICATIONS

- > Cell culture on chip
- > Cell response to medium change
- > Drug screening
- > Toxicity tests
- > Sensor testing & calibration
- > Reagent switch for flow chemistry





TECHNICAL SPECIFICATIONS

MUX DISTRIB		SPECIFICATIONS
Performances	Port to port switching time (ms)	156 ms
	Max. supported pressure	7 bar
	Internal diameter	0.5 mm
Power supply	Input voltage range, AC	100 V to 240 V
	AC supply frequency	50 Hz to 60 Hz
	Max current consumption	2A peak
	Power consumption (max)	36 W
	Power supply voltage	18-24V DC
Mechanical specifications	Valve type	12 positions / 13 ports rotative valve
	Fluidic connectors	Standard 1/4-28 UNF, flat-bottom
	Operating temperature	5 °C to 40 °C
	Operating humidity	20-70% non condensing
	Wetted materials	PCTFE and PTFE
	Dead volume ⁽¹⁾	None
Software	Computer specifications	USB 2.0 port, Intel Pentium II 500 MHz, 1 Go Hard Disk space, 2 Go RAM Windows XP and newer, 32/64 bit. LabVIEW® 2011 is required when using LabVIEW® libraries.
	Connection type	USB
	Provided elements	C++, Python, MATLAB® and LabVIEW® libraries

(1) Volume that is stuck in the system (dead end), which is not clearly swept and relies on diffusion to clear out

MUX DISTRIB DIMENSIONS without connectors (length x width x height): 133 x 156 x 133 mm

Non-contractual information, may be changed without notice.

MUX RECIRCULATION 6-PORT/2-POSITION VALVE

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-FLOW-CONTROL-SYSTEMS/MUX-RECIRCULATION/

Included in our
RECIRCULATION PACK

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-APPLICATION-PACKS/
ONE-WAY-RECIRCULATION/



MAKE LONG-TERM EXPERIMENTS EASIER AND MORE RELIABLE



The Recirculation Valve is a **6-port/2 position** microfluidic valve allowing to perform switches between two setup configurations. Applications are: **stable unidirectional fluid recirculation** and **sample injection**.

✓ **PRECISE VOLUME INJECTION**

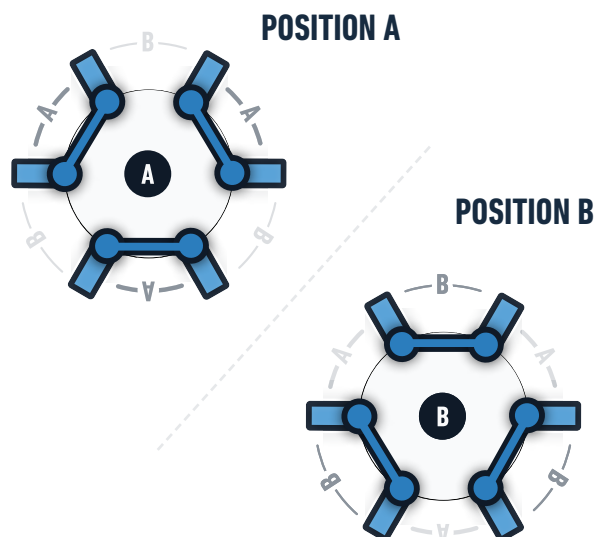
✓ **LONG RUN RECIRCULATION**

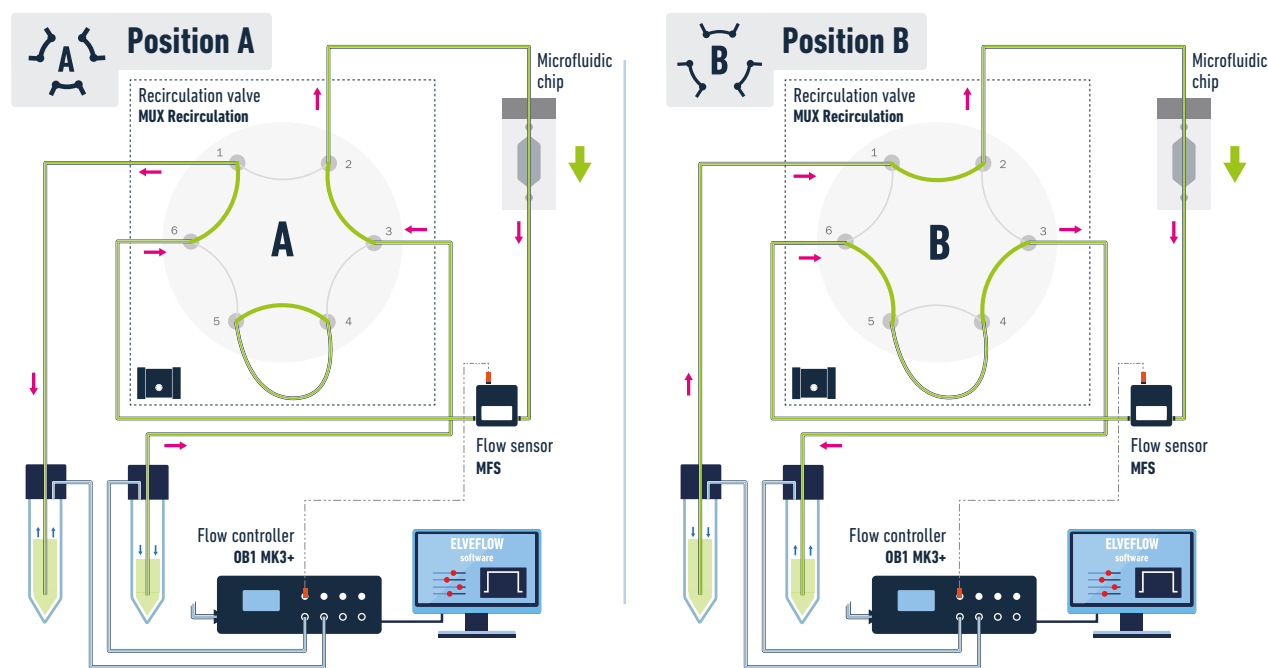
UNIQUE PERFORMANCES

- > Recirculate a fluid in a **closed loop**
- > Port-to-port switching time: **180 ms**
- > **High chemical compatibility** (wetted materials: PCTFE and PTFE)
- > No sample **cross-contamination** & no **backflow**

APPLICATIONS

- > Cell culture on chip
- > Drug screening
- > Toxicity tests
- > Stem cells assays
- > Organ on chip
- > SPR or TIR imaging coupled with microfluidics
- > Heat sink experiment





TECHNICAL SPECIFICATIONS

MUX RECIRCULATION		SPECIFICATIONS
Performances	Port to port switching time (ms)	180 ms
	Max. recommended pressure	7 bar
	Internal diameter	0.5 mm
Power supply	Input voltage range, AC	100 V to 240 V
	AC supply frequency	50 Hz to 60 Hz
	Max current consumption	2A peak
	Power consumption (max)	36 W
	Power supply voltage	18-24V DC
Mechanical specifications	Valve type	6 ports / 2 positions rotative valve
	Fluidic connector	Standard 1/4-28 UNF, flat-bottom
	Operating temperature	5 °C to 40 °C
	Operating humidity	20 to 70 % condensing
	Wetted materials	PCTFE and PTFE
	Dead volume ⁽¹⁾	None
Software	Computer specifications	USB 2.0 port, Intel Pentium II 500 MHz, 1 Go Hard Disk space, 2 Go RAM Windows XP and newer, 32/64 bit. LabVIEW® 2011 is required when using LabVIEW® libraries.
	Connection type	USB
	Provided elements	C++, Python, MATLAB® and LabVIEW® libraries

(1) Volume that is stuck in the system (dead end), which is not clearly swept and relies on diffusion to clear out

MUX RECIRCULATION DIMENSIONS without connectors (length x width x height): 133 x 156 x 133 mm

Non-contractual information, may be changed without notice.

MUX SERIES FLOW SWITCH MATRICES

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/FLOW-CONTROL-SYSTEM/FLOW-MULTIPLEXER

3 UNIQUE FLOW SWITCH MATRICES TO AUTOMATE FLOW HANDLING

✓ CONTROL UP TO 16 VALVES INDEPENDENTLY

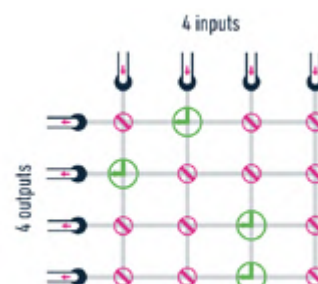
✓ SMALL FOOTPRINT



MUX CROSS CHIP

Stop the flow in microfluidic devices

- > Rocker peek valves
- > Plug & play programmable flow stop
- > Complete equilibrium, stops flow in 100ms
- > Ultra low volume injection
- > Internal/external trigger
- > Fluidic connector: 10-32 UNF



APPLICATIONS: Instantaneous stop flow, small sample injection & sample premixing

WETTED MATERIAL: POM, Viton, PEEK, FKM



MUX FLOW SWITCH

Drug switch into microdevices

- > Rocker peek valves & PEEK manifold
- > Plug & play usb software
- > No samples cross-contamination & no backflow
- > Flexible: from 4 to 256 valves
- > Internal/external trigger
- > Fluidic connector: 1/4-28 UNF



APPLICATIONS: Drug, reagent & cell medium switch for cell biology and flow chemistry

WETTED MATERIAL: PEEK, FKM



MUX QUAKE VALVE

Open & close bilayer PDMS valves

- > Plug & play programmable valve sequence
- > Fast valve switch
- > Fine valve position tuning
- > Flexible: from 16 to 256 peek valves
- > Internal/external trigger
- > Fluidic connector: 10-32 UNF



*basic example

APPLICATIONS: PDMS microvalves & micropumps and cell confinement device control

WETTED MATERIAL: POM, Viton, PEEK, FKM

MUX SERIES		CROSS CHIP	FLOW SWITCH MATRIX	QUAKE VALVE
Performances	Valves actuation time	20 ms		
	Max. supported pressure	2 bar (29 PSI)		
Power supply	Input voltage range, AC	100 V to 240 V		
	AC supply frequency	50 Hz to 60 Hz		
	Input current, AC	1 A		
	Power consumption	35 W		
	Safety	IEC/EN 61010-1: 2001		
	Shutting down power supply	disconnect AC/DC adapter		
Mechanical specifications	Valve type	2/2-way solenoid valve		3/2-way solenoid valve
	Input/output connectors	10-32 UNF	1/4-28 UNF	10-32 UNF
	Wetted materials	POM, Viton, PEEK, FKM	PEEK, FKM	POM, Viton, PEEK, FKM
	Operating temperature	10 °C to 40 °C		
	Operating humidity	20 to 80 %		
Software	Computer specifications	USB 2.0 port, Intel Pentium II 500 MHz, 1 Go Hard Disk space, 2 Go RAM Windows XP and newer, 32/64 bit. LabVIEW® 2011 is required when using LabVIEW® libraries.		
	Connection type	USB		
	Provided elements	C++, Python, MATLAB® and LabVIEW® libraries		

Non-contractual information, may be changed without notice.

MUX SERIES DIMENSIONS without connectors (length x width x height): 220 x 130 x 130 mm **TTL TRIGGER:** input/output 5 V

MUX WIRE VALVES & VALVE CONTROLLER

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/FLOW-CONTROL-SYSTEM/MMW-MICROFLUIDIC-MUX-WIRE/

PLUG YOUR VALVES ANYWHERE IN YOUR MICROFLUIDIC SETUP

✓ MIX ALL KINDS OF VALVES

✓ PLUG FROM 1 TO 8 VALVES

✓ EASILY STACK THEM



LOW PRESSURE VALVE 2-WAY OR 3-WAY

2-WAY: Pick default setting: open or closed

- > Compatible with gas or liquid
- > ROCKER® valve technology (flow displacement < 10 nL)
- > Low internal volume: 20 µL & orifice diameter 1.4 mm
- > Wide pressure range: -0.75 bar to 2.5 bar (-11 psi to 37 psi)
- > High chemical resistance. Wetted materials: PEEK + FKM + PVDF and on-demand options: (PEEK or PFA) + (EPDM or FKM or Kalrez) + (PFA or PVDF)



HIGH PRESSURE VALVE 2-WAY OR 3-WAY

2-WAY: Pick default setting: open or closed

- > Compatible with gas or liquid
- > ROCKER® valve technology (flow displacement < 10 nL)
- > Low internal volume: 50 µL & orifice diameter: 1.6 mm
- > Wide pressure range: 0 bar to 4.5 bar (0 psi to 65 psi)
- > High chemical resistance. Wetted materials: PEEK + FKM + PVDF and on demand options: (PEEK or PFA) + (EPDM or FKM or Kalrez) + (PFA or PVDF)



CUSTOM MANIFOLD

On-demand design

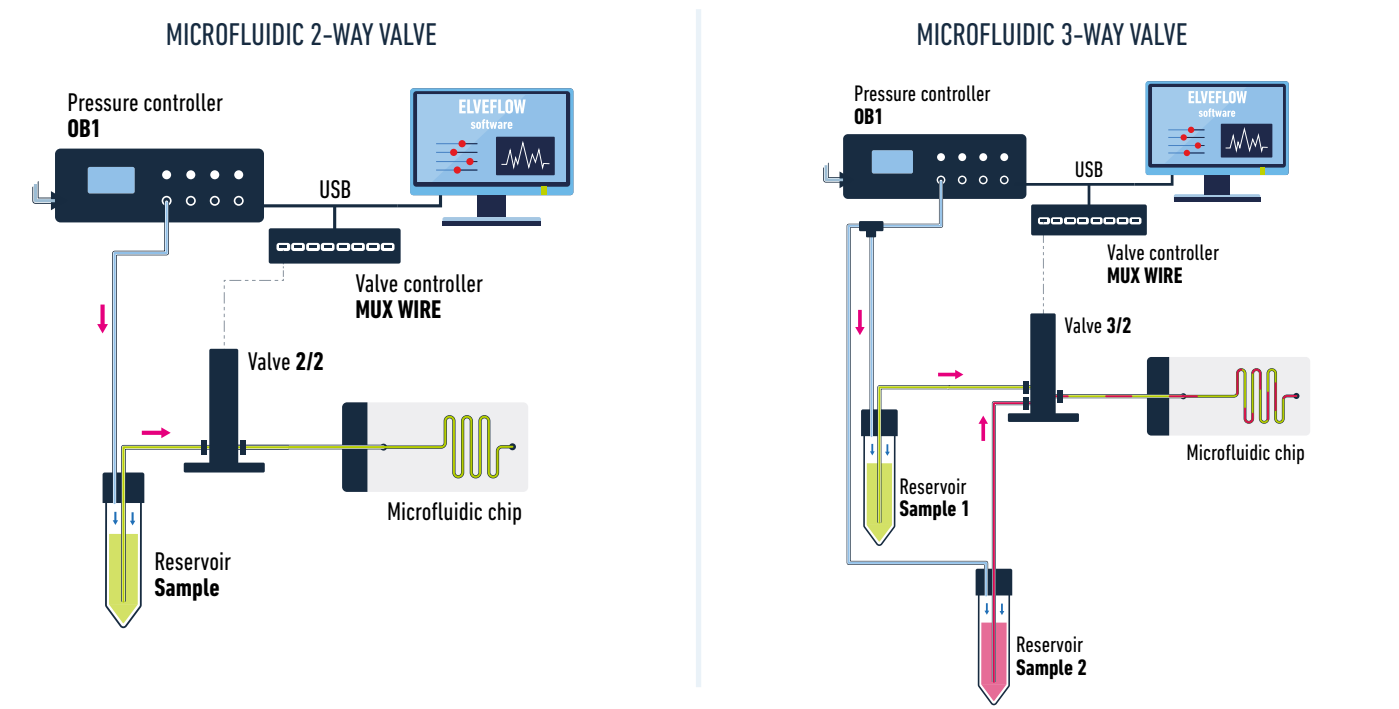
- > We design on demand any fluidic manifold compatible with our valves to meet your requirements.
- > For instance, we can provide you with 4/1 valves with 20 ms closing time.



VALVE CONTROLLER

Easily control your microfluidic valves

- > Fast liquid switching
- > Liquid sampling
- > Stop and go flows
- > Complex sequences of injection including flushing, rinsing, and sequential injection of several liquids



TECHNICAL SPECIFICATIONS

VALVES	VALVES DESIGN		
Low pressure valve -0.75 bar to 2.5 bar (-11 psi to 37 psi) With casing - Fittings: 1/4-28"2 20ms actuation time	2-way Normally open	2-way Normally closed	3-way
High pressure valve 0 bar to 4.5 bar (0 psi to 65 psi) Without casing - Fittings: 10-32" 20ms actuation time	2-way Normally open	2-way Normally closed	3-way
Wetted materials (all valves)	PEEK + FKM + PVDF on demand options: (PEEK or PFA) + (EPDM or FKM or Kalrez) + (PFA or PVDF)		

VALVES 2/2 & 3/2 DIMENSIONS without connectors (length x width x height): 19 x 30 x 115 mm

BASE: 62 x 62 mm

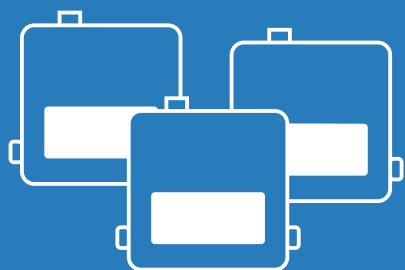
Non-contractual information, may be changed without notice.

VALVE CONTROLLER	SPECIFICATIONS
Number of controlled valves	8
Bus interface	USB 2.0
Power supply	24 VDC, 1.5 A
Max total power (sum of the power of all connected valves)	35 W
Max valve power	10 W
Valve connectors	MICRO USB

VALVE CONTROLLER DIMENSIONS without connectors (length x width x height): 128 x 81.5 x 31 mm

WEIGHT: 251 g TTL TRIGGER: input/output 5 V

Non-contractual information, may be changed without notice.



PRODUCTS

MEASUREMENT & DETECTION



MFS

THERMAL BASED FLOW SENSOR

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MICROFLUIDIC-LIQUID-MASS-FLOW-SENSORS/



HIGH-ACCURACY FLOW MONITORING AND CONTROL



High accuracy liquid volumetric flow sensors for **ultra low flow rate monitoring**. The thermal based flow sensor comes with an M8 4 pin electrical connection, it can be controlled directly through the Elveflow software.

✓ **5 FLOW RATE RANGES**

✓ **HIGH CHEMICAL COMPATIBILITY**

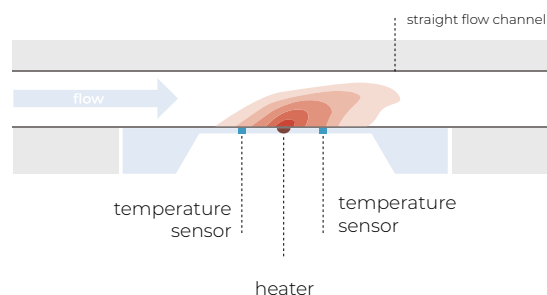
UNIQUE PERFORMANCES

- > Calibrated flows **from 0.07 $\mu\text{L}/\text{min}$ to 5,000 $\mu\text{L}/\text{min}$**
- > Sensor response time: **40 ms**
- > Resolution **down to 1.5 pL/s**
- > Wetted materials: **glass or quartz**

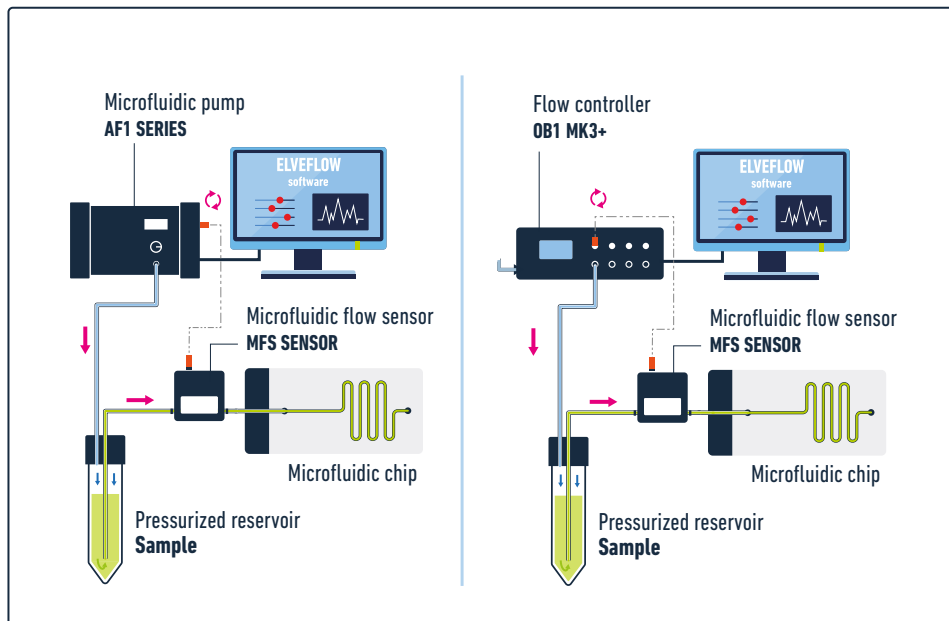
APPLICATIONS

- > Couple with an OB1 flow controller for direct flow rate control
- > Bi-directional flow rate measurement (positive & negative)

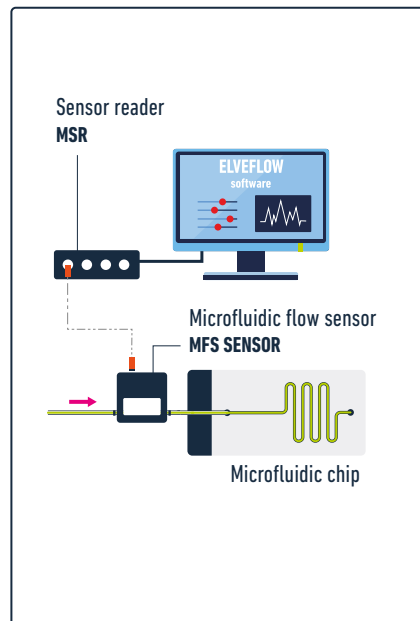
PRINCIPLE



WITH ELVEFLOW FLOW CONTROLLERS: MONITORING + CONTROL

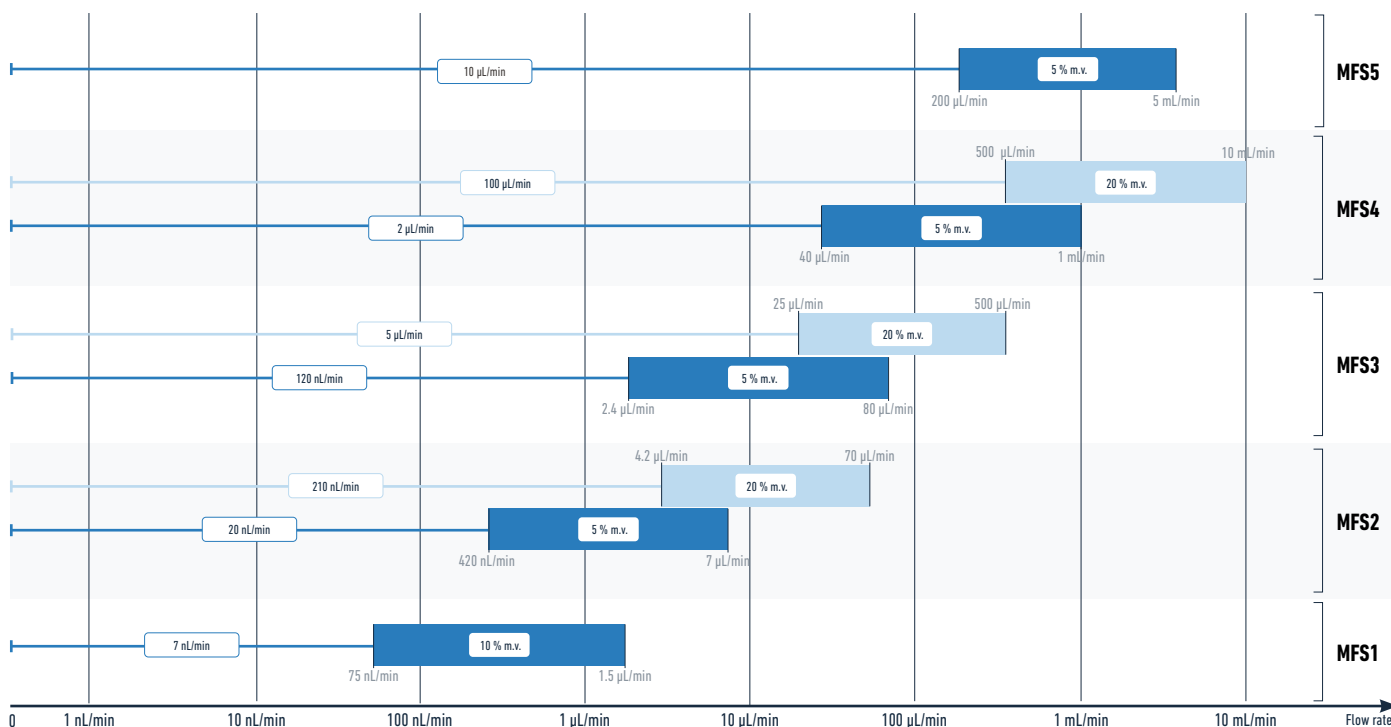
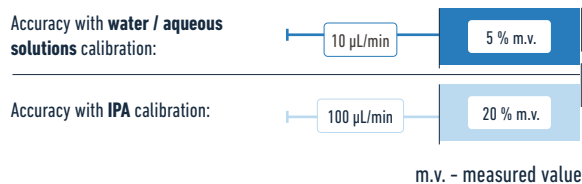


WITH SENSOR READER: MONITORING



TECHNICAL SPECIFICATIONS

MFS FLOW RATE RANGES AND ACCURACY



MFS FLOW SENSORS	MFS 1	MFS 2		MFS 3		MFS 4		MFS 5
Media calibration	water / aqueous solutions	water / aqueous solutions	IPA	water / aqueous solutions	IPA	water / aqueous solutions	IPA	water / aqueous solutions
Flow rate range	0 to ± 1.5 µL/min	0 to ± 7 µL/min	0 to ± 70 µL/min	0 to ± 80 µL/min	0 to ± 500 µL/min	0 to ± 1 mL/min	0 to ± 10 mL/min	0 to ± 5 mL/min
Accuracy m.v. - measured value applies to negative values (bi-directional)	7 nL/min between [0 to 75] nL/min	20 nL/min between [0 to 0.42] µL/min	210 nL/min between [0 to 4.2] µL/min	120 nL/min between [0 to 2.4] µL/min	5 µL/min between [0 to 25] µL/min	2 µL/min between [0 to 0.04] mL/min	100 µL/min between [0 to 0.5] mL/min	10 µL/min between [0 to 200] µL/min
	10 % m.v. between [75 to 1,500] nL/min	5 % m.v. between [0.42 to 7] µL/min	20 % m.v. between [4.2 to 70] µL/min	5 % m.v. between [2.4 to 80] µL/min	20 % m.v. between [25 to 500] µL/min	5 % m.v. between [0.04 to 1] mL/min	20 % m.v. between [0.5 to 10] mL/min	5 % m.v. between [0.2 to 5] mL/min
Repeatability m.v. - measured value applies to negative values (bi-directional)	0.9 nL/min between [0 to 80] nL/min	3.5 nL/min between [0 to 0.7] µL/min	7 nL/min between [0 to 0.7] µL/min	8 nL/min between [0 to 1.4] µL/min	0.25 µL/min between [0 to 25] µL/min	0.2 µL/min between [0 to 0.04] mL/min	5 µL/min between [0 to 0.5] mL/min	1 µL/min between [0 to 0.2] mL/min
	< 1 % m.v. between [80 to 1,500] nL/min	0.5 % m.v. between [0.7 to 7] µL/min	1 % m.v. between [0.7 to 70] µL/min	0.5 % m.v. between [1.4 to 80] µL/min	1 % m.v. between [25 to 500] µL/min	0.5 % m.v. between [0.04 to 1] mL/min	1 % m.v. between [0.5 to 10] mL/min	0.5 % m.v. between [0.2 to 5] mL/min
Pressure drop at full scale flow rate, 23 °C	1 bar	3 mbar	60 mbar	1 mbar	7 mbar	< 1 mbar	5 mbar	< 1 mbar
Total internal volume	1 µL	1.5 µL		5 µL		25 µL		80 µL
Sensor inner diameter	25 µm	150 µm		430 µm		1.0 mm		1.8 mm
Tubing inner length	29 mm							
Operating pressure	200 bar			100 bar		15 bar		15 bar
Burst pressure	400 bar			200 bar		30 bar		30 bar
Microfluidic fitting type	UNF 1/4-28							
Wetted material	PEEK							
Internal sensor capillary material	Quartz					Borosilicate glass		

Non-contractual information, may be changed without notice.

ELECTRICAL INPUT: 8V  7 mA ANALOG OUTPUT: 0 - 5 V FLOW SENSOR SIZE (length x width x height): 58 x 52 x 23 mm WEIGHT: 102 g

Excellent chemical resistance and bio-compatibility are ensured
 Liquid Flow Sensor enables fast, and non invasive measurements of very low liquid flow rate below 5mL/min
 The product comes fully calibrated for water
 Flow calibration for methanol or other media is available on request (all data for medium H2O, 20°C, 1 bar unless otherwise noted)

The recommended storage temperature ranges from -10°C to +60°C
 The operating temperature is +10°C to +50°C
 The flow sensor shows bi-directional and linear transfer characteristics

BFS

CORIOLIS BASED FLOW SENSOR

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MICROFLUIDIC-FLOW-SENSOR-CORIOLIS/



COMPATIBLE WITH ALL LIQUIDS: WATER, OIL, ALCOHOL, MIXTURE...
WITH NO CALIBRATION REQUIRED



In partnership with **Bronkhorst**, we have developed a unique Coriolis flow sensor suited to microfluidics. It offers various benefits: **precision, wide range, straightforward compatibility with all liquids** (no calibration needed).

✓ **COMPATIBLE WITH ALL LIQUIDS & GAS**

✓ **NO CALIBRATION NEEDED**

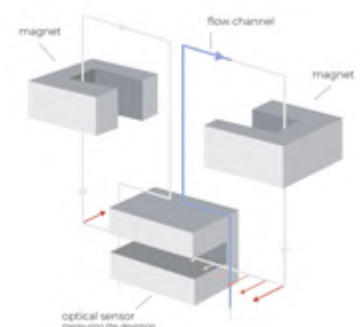
UNIQUE PERFORMANCES

- > Large flow range **from 1.6 $\mu\text{L}/\text{min}$ to 500 mL/min** (for water)
- > Maximum flow rate: **500 mL/min** (for water)
- > Sensor response time: **35 ms**
- > Mass flow accuracy: **down to 2 %** of measured value (down to 0.2 % of mv on request)

APPLICATIONS

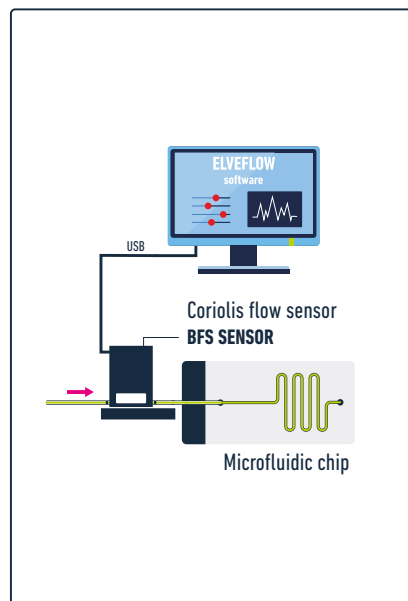
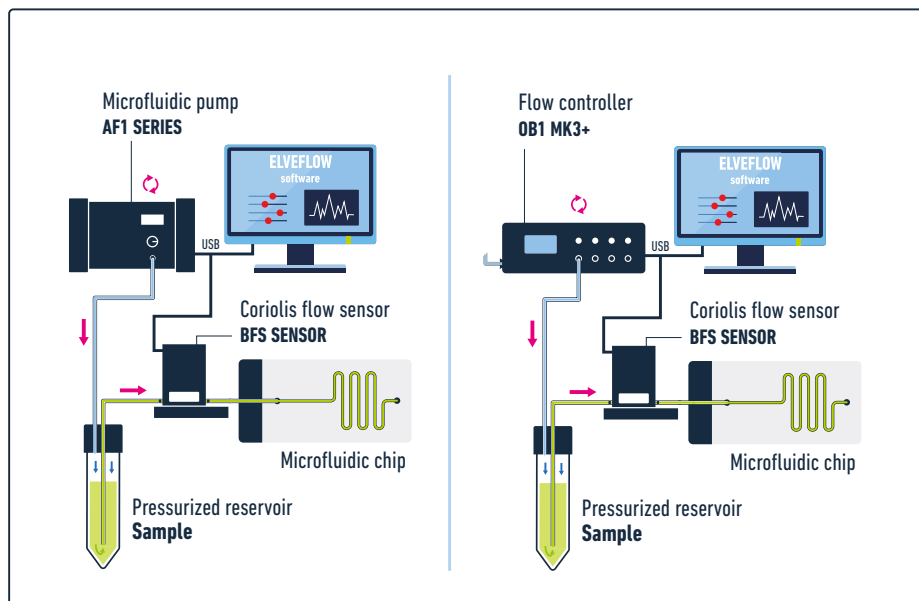
- > Compound semiconductor processing
- > Solar cell and FDP technology
- > Food and pharmaceutical industries
- > Medical microchemical or analytical installations
- > Calibration laboratories

PRINCIPLE



WITH ELVEFLOW FLOW CONTROLLERS: MONITORING + CONTROL

WITH EXTERNAL EQUIPMENT: MONITORING



TECHNICAL SPECIFICATIONS

CORIOLIS FLOW SENSOR	BFS 1	BFS 1+	BFS 2	BFS 3
Flow range	0.1 g/h to 200 g/h		1 g/h to 2000 g/h	30 g/h to 30000 g/h
Minimum flow rate (water)	1.6 µL/min		16.6 µL/min	500 µL/min
Maximum flow rate (water)	3.3 mL/min		33.3 mL/min	500 mL/min
PERFORMANCE				
Mass flow accuracy liquids	down to ± 2 % of measured value	down to ± 0.2 % of measured value		
Mass flow accuracy gases	up to ± 0.5 % o measured value			
Repeatability	± 0.05 % of rate ± 1/2 (ZS* x 100/flow) % based on digital output			
Zero stability (ZS) ⁽¹⁾	< ± 0.01 g/h		< ± 0.2 g/h	< ± 6 g/h
Density accuracy	< ± 5 kg/m³			
Temperature accuracy	± 0.5 °C			
Temperature effect ⁽²⁾	Zero drift: ± 0.01 g/h/°C		Zero drift: ± 0.02 g/h/°C	Zero drift: ± 0.5 g/h/°C
Mounting ⁽³⁾	Any position, attitude sensitivity negligible			
Device temperature	0...70 °C			
Response time (t 98 %)	0.2 s to fill the tubing then 35 ms			
MECHANICAL PARTS				
Wetted material	Stainless steel 316 L or comparable		Stainless steel 316 L or comparable	
			Optional: Hastelloy-C22	Optional: Hastelloy-C23
Pressure rating	200 bar		200 bar; higher on request	
Sensor inner diameter	250 µm		0.5 mm	1.3 mm
Suitable tubings	1/16"		1/16" (1/8" on request)	
Internal volume	13 µL		0.45 mL	0.82 mL
Calibration	/	Individual calibration certificate		

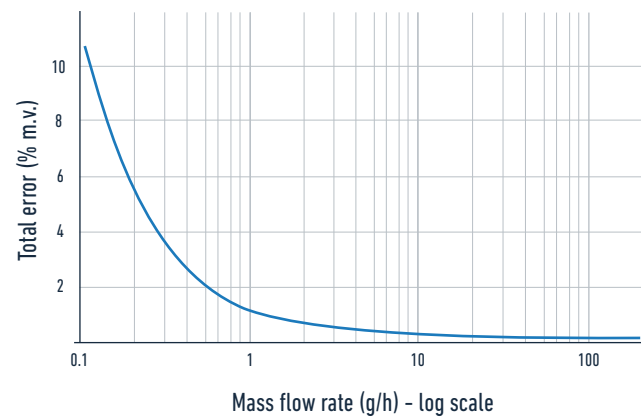
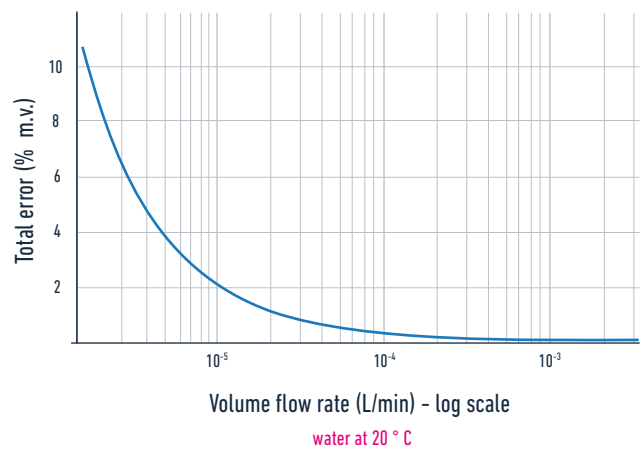
FLOW SENSOR SIZE (length x width x height): 65 x 32 x 144 mm WEIGHT: 3 kg

Non-contractual information, may be changed without notice.

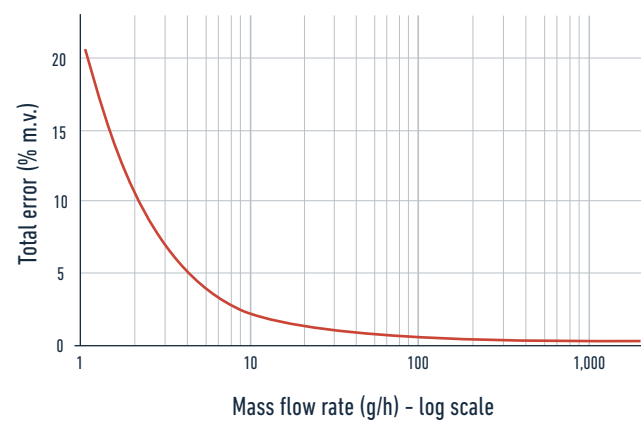
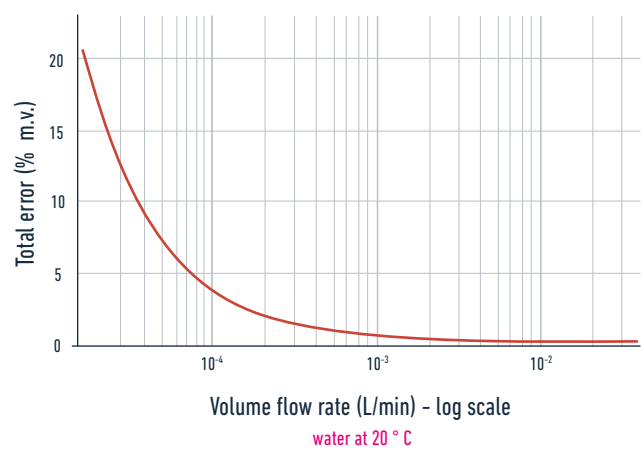
(1) Guaranteed at constant temperature and for unchanging process and environment conditions. (2) Depends on flow rate, heat capacity fluid, T amb., T fluid and cooling capacity.
(3) To be rigidly bolted to a stiff and heavy mass or construction for guaranteed stability. External shocks or vibrations should be avoided.

TOTAL ERROR = ACCURACY READING ± [(ZERO STABILITY / FLOW) X 100] [% READING]
m.v. - measured value

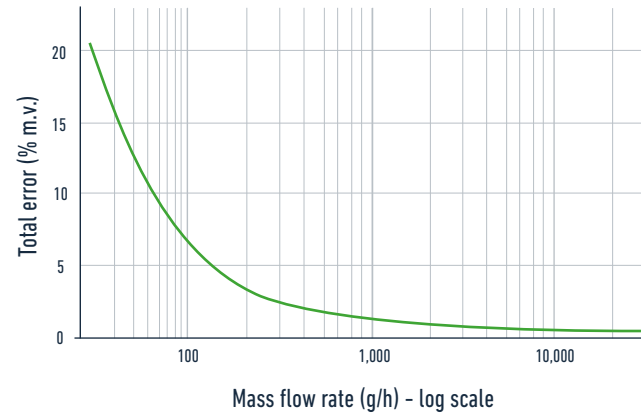
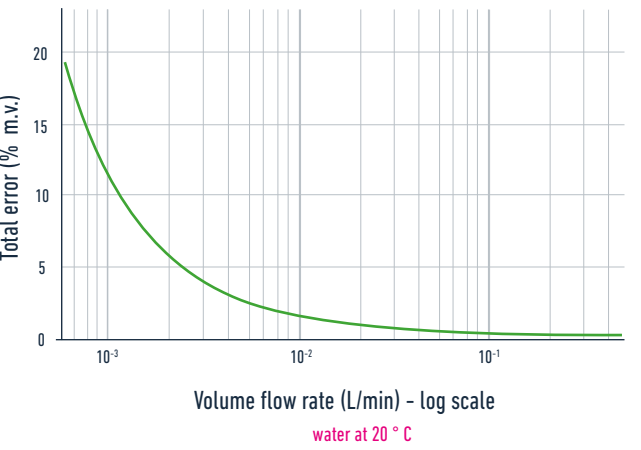
BFS 1+



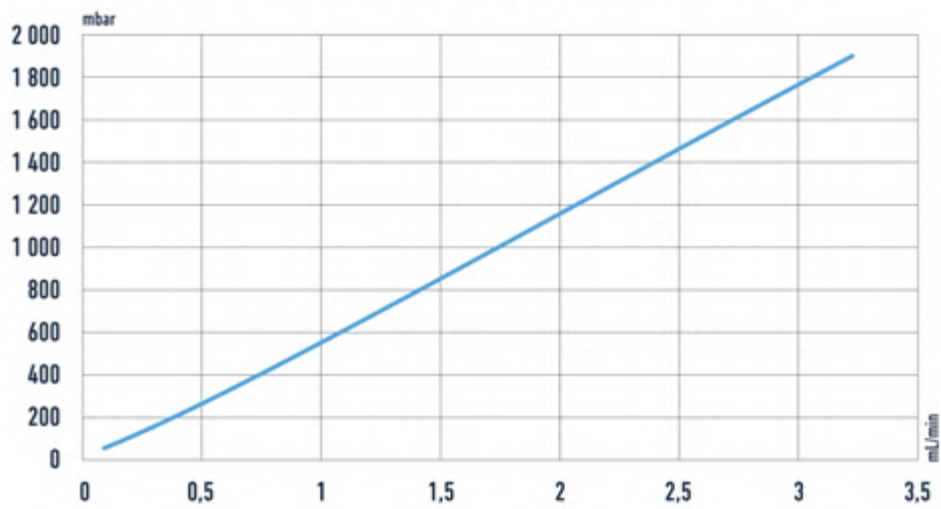
BFS 2



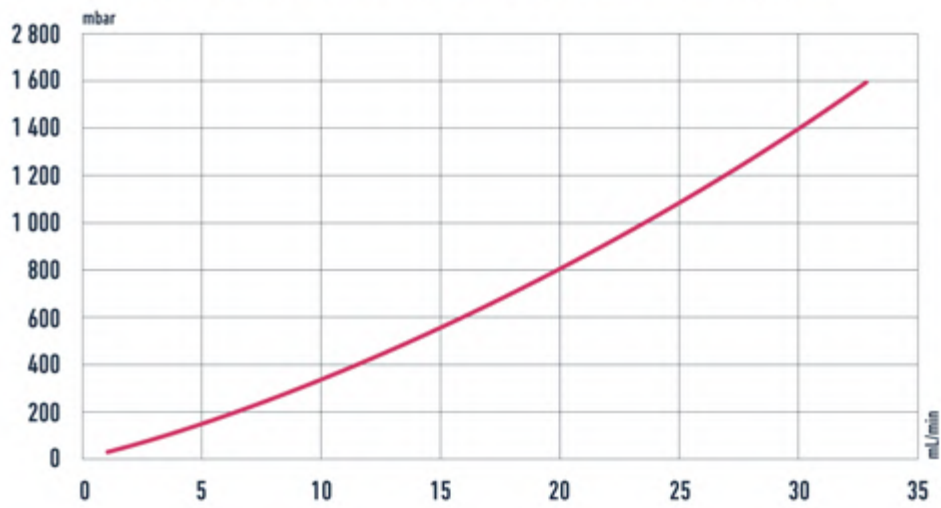
BFS 3



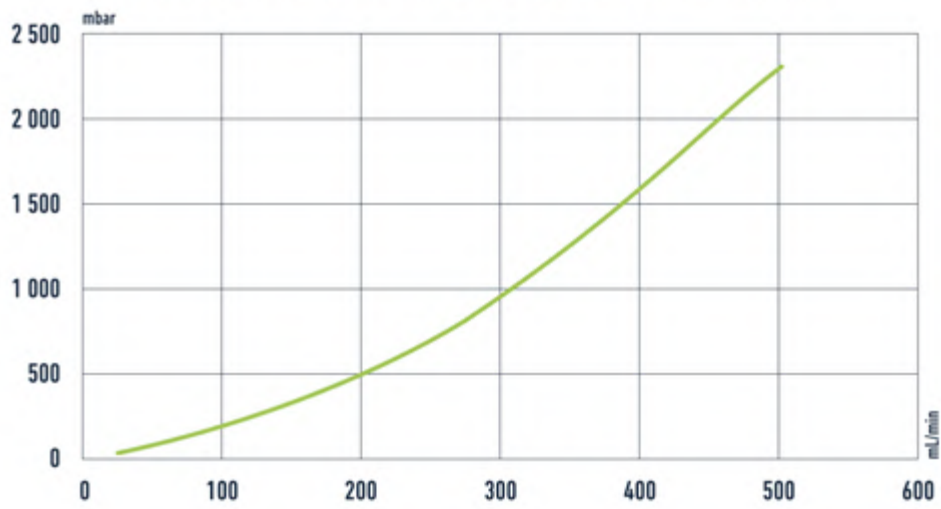
BFS 1 FLOW SENSOR PRESSURE DROP VS FLOW RATE (FOR WATER @20°C)





BFS 2 FLOW SENSOR PRESSURE DROP VS FLOW RATE (FOR WATER @20°C)



BFS 3 FLOW SENSOR PRESSURE DROP VS FLOW RATE (FOR WATER @20°C)



FLOW SENSORS COMPARISON MFS VS BFS

FLOW SENSORS COMPARISON		 BFS (1 & 1+)	 MFS
Accuracy	0.2 % of measured value ⁽¹⁾	5 % of measured value	
Range	One sensor for 1.6 µL/min to 3 mL/min	Five sensors from 10 nL/min to 5 mL/min	
Negative flow measurement	Yes	Yes	
Supported fluid types	All without calibration	All with calibration	
Response time	35 ms ⁽²⁾	From 1 to 70 ms ⁽³⁾	
Flow sensor size	65 x 32 x 144 mm	58 x 53 x 23 mm	
Internal diameter	250 µm	From 25 µm to 1.8 mm ⁽⁴⁾	
Weight	3 kg	100 g	
Connectors	1/16" OD tubing	1/16" OD tubing	
Internal volume	13 µL	From 1 µL to 80 µL ⁽⁴⁾	
Wetted material	Stainless steel 316L or comparable	Glass or Quartz	
Principle	Coriolis	Thermal	
Computer connection	Directly via USB to the computer	Directly on the OB1 and the AF1 or with the Sensor reader MSR	
Additional features	Temperature and density measurement		

Non-contractual information, may be changed without notice.

(1) Available upon request. 2 % accuracy for the regular model

(2) 0.2 s at 98 % (spec) to fill the tubing then 35 ms with temperature measurement

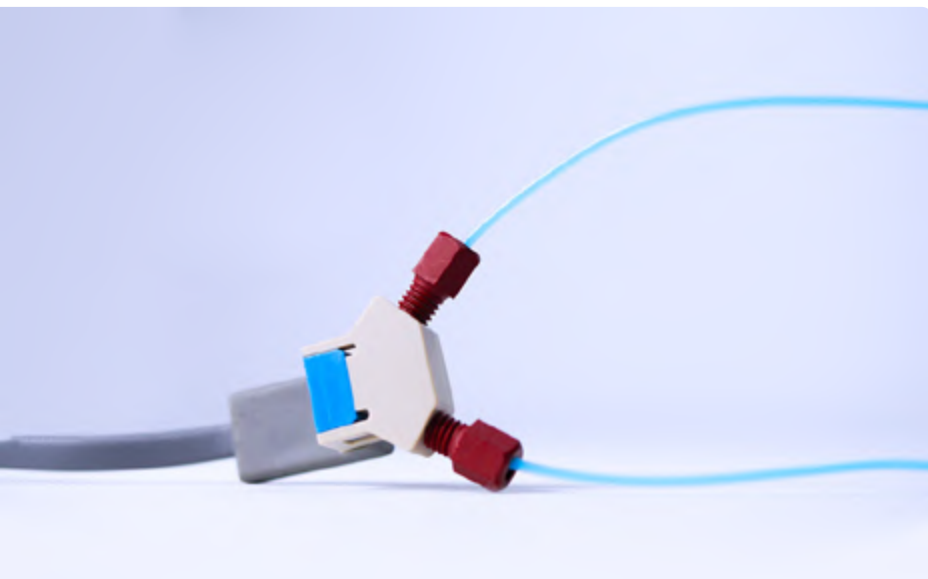
(3) Depending on chosen digital resolution

(4) Depending of the sensor range

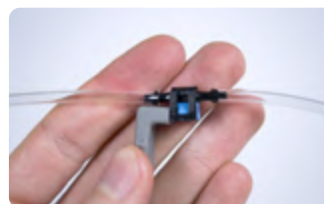
MPS

LOW VOLUME PRESSURE SENSOR

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MICROFLUIDIC-LIQUID-FLOW-THROUGH-PRESSURE-SENSOR/



**MEASURE AND
CONTROL PRESSURE
ANYWHERE IN YOUR
SETUP**



High accuracy pressure sensor adapted to liquid and gas and compatible with 3/32" ID tubing or 10-32 fittings for 1/16" OD tubing. Monitor **low pressure flow rate** in your microfluidic setup.

✓ **PRESSURE FEEDBACK OPTION**

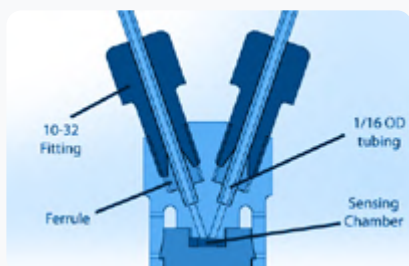
✓ **MEASUREMENT & DETECTION**

UNIQUE PERFORMANCES

- > Accuracy **down to 0.2 % FS**
- > 5 ranges **from 70 mbar to 7,000 mbar**
- > Internal volume: **7 μ L**
- > Settling time: **20 ms**
- > Works with both **liquid & gas**

APPLICATIONS

- > You can plug our pressure sensor anywhere within your microfluidic setup, record the pressure on your computer and adjust it accordingly using our pressure pumps.




OUR PRESSURE SENSORS WORK AS GAUGE PRESSURE SENSORS,

measuring positive and negative pressure relatively to atmospheric pressure.

MICROFLUIDIC PRESSURE SENSOR		MPS 0	MPS 1	MPS 2	MPS 3	MPS 4
Pressure range		-70 to 70 mbar (-1 to 1 psi)	-340 to 340 mbar (-5 to 5 psi)	-1 to 1 bar (-15 to 15 psi)	-1 to 2 bar (-15 to 30 psi)	-1 to 7 bar (-15 to 100 psi)
Maximum overpressure		20 psi	20 psi	45 psi	60 psi	200 psi
Pressure accuracy liquids		up to ± 0.5 % of max range	up to ± 2 % of max range	up to ± 0.2 % of max range		
Linearity %span	Typical	0.25	0.4	0.25	0.1	0.4
	Max.	0.5	0.5	0.5	0.2	0.6
Repeatability & hysteresis %span		± 3.0	± 0.4	± 0.2		
Operating temperature		-40 °C to +85 °C				
Specified temperature range		0 °C to +50 °C				

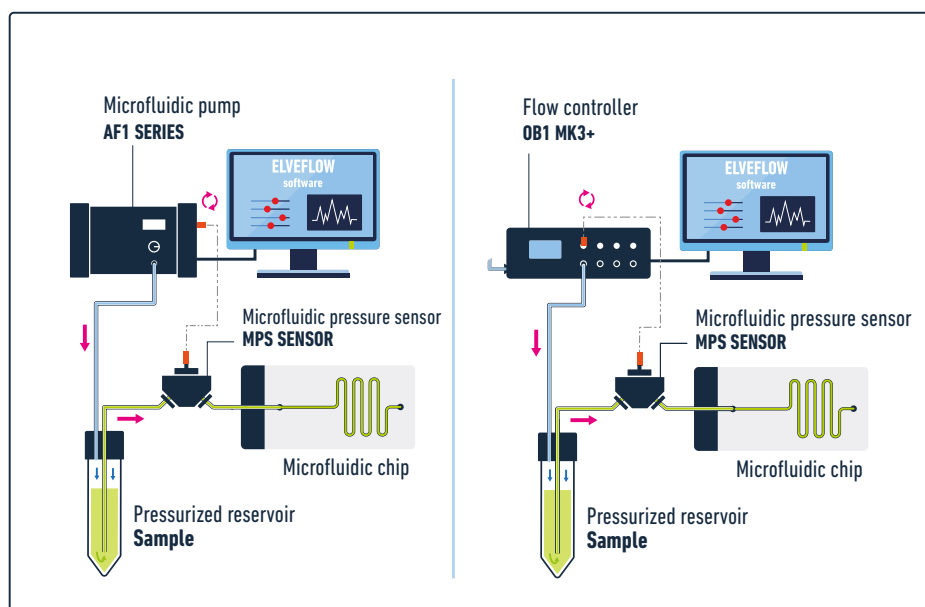
Non-contractual information, may be changed without notice.

PACKAGE MODEL	LARGE	SMALL
Sensor design		
Connection type	3/32 barb	10-32 thread with ferrule
Internal volume	70 μ L	7.5 μ L
Recommended tubing diameter (inch)	3/32" ID	1/16" OD
Wetted materials	polyetherimide, silicon and fluorosilicone seal	PEEK, silicon and fluorosilicone seal
Electrical connection	4 point measurement M8 connector compatible with Elveflow Sensor Reader and a Sensor Reader	

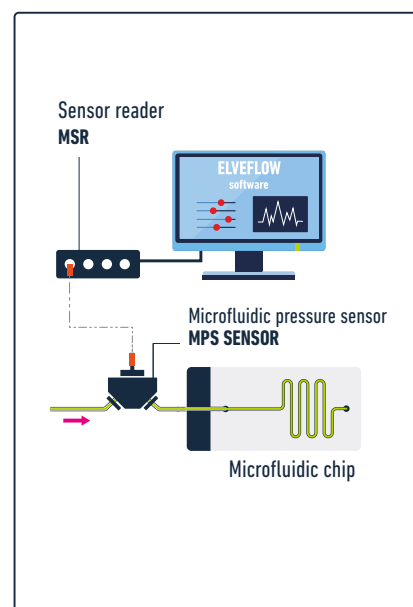
Non-contractual information, may be changed without notice.

SENSOR SIZE (length x width x height): **LARGE:** 29 x 13 x 27 mm **SMALL:** 40 x 33 x 19 mm **AMPLIFICATION MODULE SIZE:** 52 x 24 x 24 mm

WITH ELVEFLOW PRESSURE CONTROLLERS: MONITORING + CONTROL



WITH SENSOR READER: MONITORING



MFP

LUER-LOCK PRESSURE SENSOR

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MFP-MICROFLUIDIC-INLINE-PRESSURE-SENSOR/



MEASURE AND CONTROL PRESSURE OVER A LARGE RANGE



Flow-through pressure sensors adapted to gases or liquids, and compatible with the Luer-lock standard. The flowplus fluid sensor is intended to **measure the pressure** of fluid media flowing through the sensor.

✓ **HIGH CHEMICAL COMPATIBILITY**

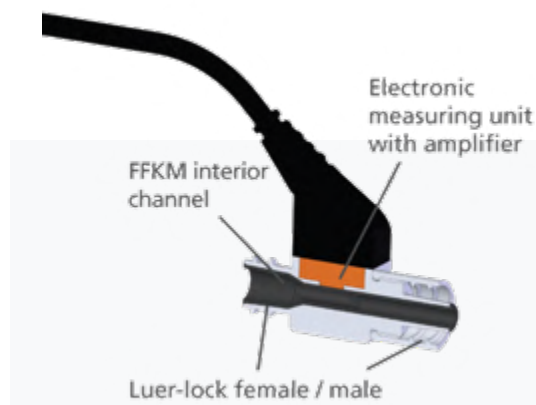
✓ **UP TO 16 BAR**

UNIQUE PERFORMANCES

- > Accuracy **up to 2 % FS**
- > 1 ranges **0 - 16 bar** - Overlay 25 bar
- > **No dead volume**
- > Flow rate **up to 100 mL/min**
- > Versatile: works with **gas & liquid**

APPLICATIONS

- > You can plug our pressure sensor anywhere within your microfluidic setup, record the pressure on your computer and adjust the pressure or flow accordingly using our pressure pumps.



WIDE MEDIA COMPATIBILITY

(material in contact: FFKM) FDA-certified and therefore, suitable for food industry use.

LUER-LOCK PRESSURE SENSOR	SPECIFICATIONS
Maximum flowrate ⁽¹⁾	100 mL/min
Pressure range	0 to 16 bar
Power supply	12 to 30 VDC
Wetted materials	interior flow channel: FFKM
Housing	coated aluminum
Output signal	0.1 to 10 V
Electrical connection	"push-pull" connector / M8 sensor plug
Mechanical connection	LUER-LOCK DIN EN 1707
Temperature range	15 to 45 °C
Internal volume	205 µL
Dimensions	inner diameter: between 4 mm and 1.8 mm length: 31.2 mm

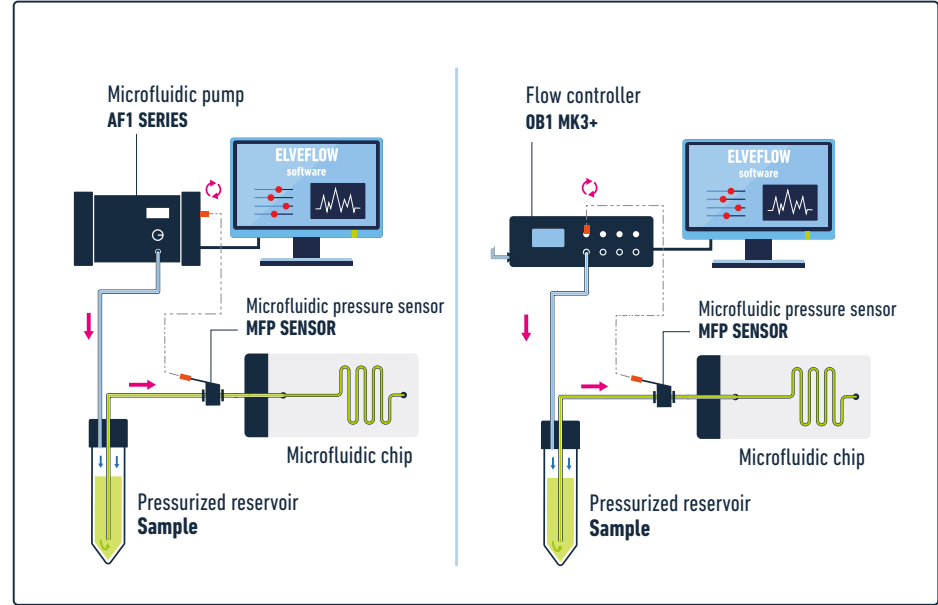
(1) Depends on the viscosity and primary pressure of the medium

Non-contractual information, may be changed without notice.

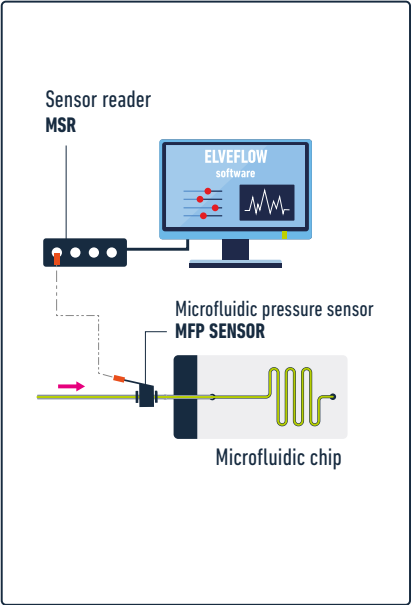
SENSOR SIZE (length): 31.2 mm

OUR PRESSURE SENSORS WORK AS GAUGE PRESSURE SENSORS,
measuring pressure relatively to atmospheric pressure.

WITH ELVEFLOW FLOW CONTROLLERS: MONITORING + CONTROL



WITH SENSOR READER: MONITORING



MBD

MICROFLUIDIC BUBBLE DETECTOR

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MICROFLUIDIC-LIQUID-SENSOR/



CHECK IF LIQUID IS PRESENT IN CLEAR TUBING



The sensor is able to **detect the presence of fluids inside clear tubing, trigger a signal to another instrument** and act accordingly - such as stop, wait a certain amount of time, allow enough flow to clear the tubing, or reset the sensor.

✓ **BUBBLE MONITORING**

✓ **LIQUID INTERFACES DETECTION**

UNIQUE PERFORMANCES

- > Cost-effective compared to camera
- > Based on true/false logic
- > Reliable non invasive technique
- > Prevents damage in cells with bubble bursts
- > The microfluidic bubble detector comes in two different casings suited to the use with 1/16" or 1/4" outside diameter tubes

APPLICATIONS

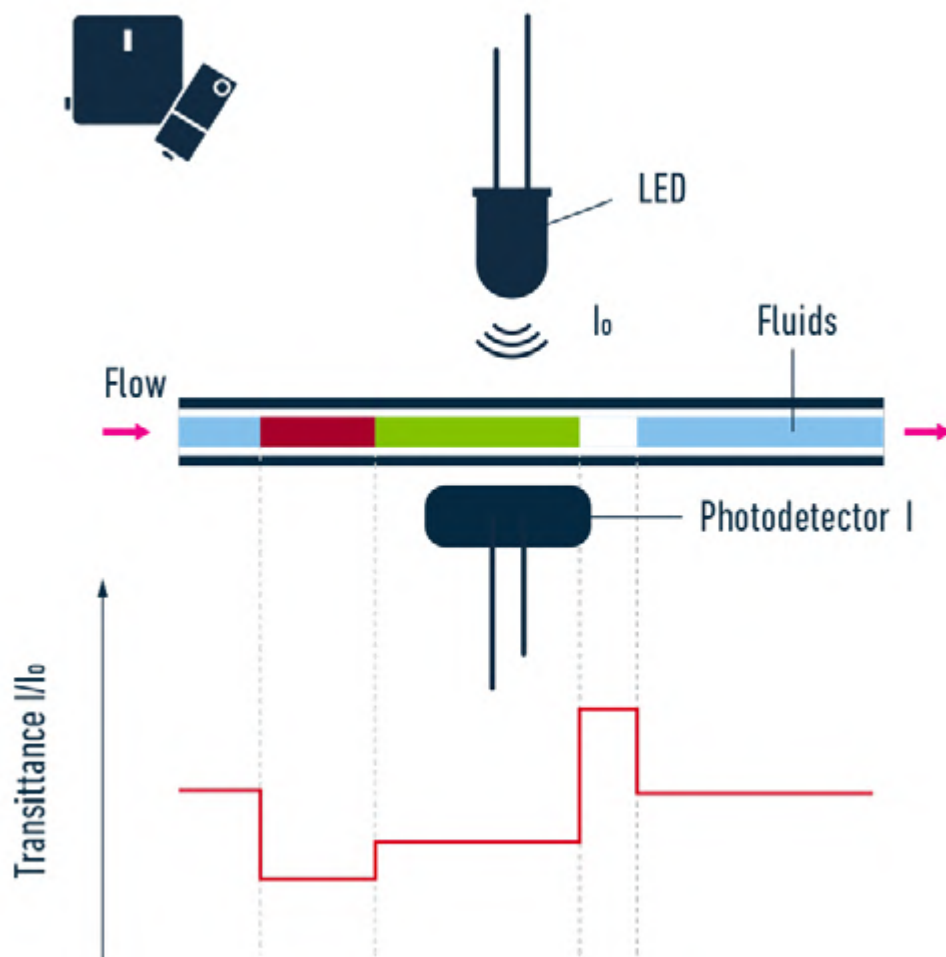
- > Bubble detection
- > Liquid level sensing
- > Blood processing equipment
- > Patient connected medical devices
- > Perform bilateral recirculation based on air detection

DETECTION MODULE SIZE (length x width x height): 68 x 29 x 33 mm **AMPLIFICATION MODULE SIZE:** 69 x 59 x 22 mm

HOW IT WORKS

A light beam is emitted by a LED at known power. This light beam goes through the capillary and the fluid passing through. It is then collected by an NPN silicon phototransistor. This phototransistor converts the light power into an electrical power. When a fluid changes, the optical index and the light absorption coefficient change accordingly. It induces a change in the electrical power and allows to detect changes in the fluid.

WAVELENGTH = 890 nm



MSR SENSOR READING UNIT

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-FLOW-CONTROL-MODULE/MSR-MICROFLUIDIC-SENSOR-READER-V2/



AN ACQUISITION INTERFACE FOR ALL SENSORS



The sensor reader is an interface allowing the **acquisition** of many kinds of **analog & digital sensors**, including Elveflow pressure sensors and flow sensors.

✓ **MONITOR UP TO 4 SENSORS**

✓ **REAL-TIME CONTROL & FEEDBACK**

UNIQUE PERFORMANCES

- > Fast acquisition frequency **1 kHz**
- > From **9 to 16 bits resolution**
- > Real-time control & **feedback loops**
- > Read simultaneously **up to 4 sensors**

APPLICATIONS

- > The Sensor Reader can be used to monitor flow rate, pressure, or other physical parameters on any type of flow control instrument (syringe pump, peristaltic pump, perfusion, pressure controller)
- > It embeds two independent power supplies which allows the use of a wide variety of sensors simultaneously, functioning with different voltages for their power supply

SENSOR READER UNIT		SPECIFICATIONS	
Number of sensors	4		
Sensor connectors	M8 female (4 pins)		
USB reading current min - max	100 mA - 500 mA		
Sensor power supplies voltage (2 power supplies tunable independently each of which feeding 2 sensors)	5 - 25 V		
Total power on the 4 channels	0.9 W		
SENSOR INPUTS			
Impedance	1 MΩ		
Acquisition frequency	1 KHz		
Acquisition resolution	from 9 to 16 bits		
Input range	0 - 10 V	0 - 5 V	0 - 1 V
Resolution (1 bit)	5 mV	2.5 mV	0.5 mV
Noise (full band)	5 mV rms	2.5 mV rms	0.5 mV rms
ANALOG LOW-PASS FILTER FUNCTION CHARACTERISTICS			
Cutoff frequency	60 Hz		
Filter order	3		

SENSOR READER SIZE without connectors (length x width x height): 91 x 69 x 29 mm **WEIGHT:** 320 g

Non-contractual information, may be changed without notice.

ESI ELVEFLOW SOFTWARE

ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/FLOW-CONTROL-SYSTEM/ELVEFLOW-SOFTWARE/

ESI - ELVEFLOW SMART INTERFACE A UNIQUE SOFTWARE FOR ALL INSTRUMENTS

✓ **DIRECTLY INPUT FLOW RATE**

✓ **CUSTOM FLOW PROFILE**

✓ **ADVANCED WORKFLOW AUTOMATION**



The **Elveflow Smart Interface** allows an intuitive control of our microfluidic instruments in a few clicks. It is designed both for basic control and **complex tasks** thanks to the use of the scheduler.

The ESI microfluidic software makes many applications easy, such as: **generation of continuous fluid streams**, **dosing of volumes**, **generation of dynamic flow profiles**, **Optomicrofluidic control**, and many more...



National Instrument is our technological partner for embedded electronics

FEATURES THAT MATTER

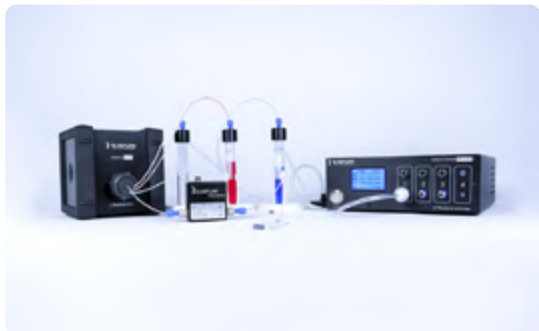
- > Pressure & flow rate **visualization** and **recording**
- > **Programming & automation** of complex sequences
- > Easy alternative instrument control through the provided **C++**, **Python**, **MATLAB®** and **LabVIEW®** libraries



APPLICATION PACKS

ELVEFLOW PACKS

[ELVEFLOW.COM/MICROFLUIDIC-FLOW-CONTROL-PRODUCTS/MICROFLUIDIC-APPLICATION-PACKS/](https://www.elveflow.com/microfluidic-flow-control-products/microfluidic-application-packs/)



ELVEFLOW APPLICATION PACKS

Our Applications Packs are **all-in-one solutions** which include everything you need to perform your microfluidic experiments successfully. Our **many configurations available** ensure that you get a microfluidic setup perfectly fitted to your needs.

<https://www.elveflow.com/microfluidics-application-packs>

DROPLET GENERATION PACK

Flow control and chip for droplet generation straight out of the box



All the required parts for researchers' needs to start making droplets and emulsions out of the box. It brings the many benefits of microfluidics, such as excellent **monodispersity**, **reproducibility** and **scalability** to your daily work in order to achieve great science.

<https://www.elveflow.com/microfluidics-application-packs/microfluidics-packs/easy-droplet-generation/>

ALGINATE BEADS GENERATION PACK

All you need to know to perform monodisperse hydrogel particle production (PDI < 5 %)



This pack contains one pumping channel to flow the aqueous alginate phase and another pumping channel to push the continuous oil phase through our droplet generation chip, enabling the generation of **alginate droplets in oil**.

<https://www.elveflow.com/microfluidics-application-packs/nanoparticles-packs/easy-microfluidic-alginate-beads-generation-pack/>

CELL & BIOLOGY PACK

Liquid handling for cell-based experimentations



All the necessary elements to create a **continuous flow** and monitor flow rate applied on the cells. Ideal for experiments requiring switches between different cell culture mediums. A computer-controlled valve allows sequential injections (up to 10 different solutions, more on demand).

<https://www.elveflow.com/microfluidics-application-packs/biology-packs/perfusion-for-cells-and-biology/>

ORGAN-ON-A-CHIP PACK

Flow control and chip solution for organ-on-chip experiments



A full microfluidic system for Organ-On-Chip experiments. This fully integrated solution contains all the required microfluidic parts for researchers to reproduce numerous characteristics of the in vivo environment of cells and tissues.

<https://www.elveflow.com/microfluidic-products/microfluidics-application-packs/organ-on-a-chip-pack/>

MICROFLUIDIC STARTER PACK

All-in-one solution to discover microfluidics



All necessary elements for you to start your own microfluidic experiments. This **easy-to-use system** covers the majority of microfluidics researchers' needs. It is fully compatible with the whole Elveflow product range, enabling you to upgrade your system as your needs grow.

<https://www.elveflow.com/microfluidic-products/microfluidics-application-packs/starter-pack/>

MICROFLUIDIC RECIRCULATION PACK

Full system for continuous unidirectional recirculation experiments

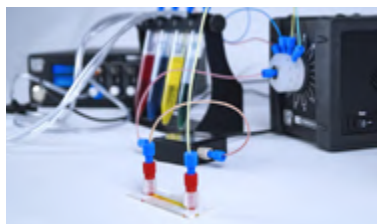


A complete system which enables automatic re-use and unidirectional recirculation of liquids in microfluidic experiments. It brings the many benefits such as **pulseless smooth flow, reproducibility, accurate and precise flow rate control**. It enables full automation of week-long experiments with limited media volumes or more advanced applications such as the modeling of complex biological flow patterns.

<https://www.elveflow.com/microfluidic-products/microfluidics-application-packs/one-way-recirculation/>

SEQUENTIAL FLUID INJECTION PACK

Quickly switch between up to 12 fluids at a controlled flow rate



This pack is dedicated to any system that requires to **quickly swap between several solutions while maintaining a precise flow rate**. This makes it a perfect fit for **biosensors, biochemical sensors or electrochemical sensors test rigs, flow chemistry, Seq-Fish, drug testing applications, and many more...**

<https://www.elveflow.com/microfluidic-products/microfluidics-application-packs/sequential-fluid-injection-pack/>

LIPID NANOPARTICLE SYNTHESIS PACK

All you need to generate liposome and lipid nanoparticles



All the parts needed to easily synthesize your lipid nanoparticles with high monodispersity, production rate and reproducibility for the optimal encapsulation of your mRNA or siRNA molecules.

www.elveflow.com/microfluidics-application-packs/nanoparticles-packs/lipid-nanoparticle-synthesis/

ACCESSORIES

ELVEFLOW ACCESSORIES

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-ACCESSORIES/



To order **Elveflow Accessories**, you can contact us directly for any quote or tech support request, or to place a purchase order, because the **Elveflow accessories team is always ready to make your experience with us a pleasure**. Alternatively, you can browse the Elveflow Accessories product line on Darwin Microfluidics and order online. Darwin Microfluidics is our new **online reseller**, so go check it out!

MICROFLUIDIC ACCESSORIES

MICROFLUIDIC RESERVOIRS
 BUBBLE REMOVER
 RESERVOIR XXS ON CHIP
 4 TUBES HOLDER
 PRESSURIZED AIR SOURCE
 VACUUM GENERATOR
 KIT FITTINGS STARTER PACK LUER
 KIT FITTINGS STARTER PACK PUSH IN
 MANIFOLD 9 PORTS
 PTFE TUBING 1/16" OD X 1/32" ID, 50M
 REMOTE FLOW CONTROL
 PRESSURE SOURCE
 VACUUM SOURCE



NEW AND IMPROVED PEEK BUBBLE TRAP



✓ **AUTOCCLAVABLE & LEAK-RESISTANT**

✓ **EASILY REPLACEABLE MEMBRANE**

This improved version of Elveflow's bubble trap is now autoclavable, thanks to the use of PEEK (Polyetheretherketone). Three internal volume versions are available: 23 µL (S), 95 µL (M), 362 µL (L).



RESERVOIRS	Volume	2 ports	4 ports
XXS	800 µL	NA	NA
XS	1.5 - 2 mL	available	not available
S	15 mL	available	available
M	50 mL	available	available
L	100 mL	available	available
HP	150 mL	available	not available

Non-contractual information, may be changed without notice.

RESERVOIRS SPECIFICATIONS DEDICATED TO THE OB1 PRESSURE CONTROLLER

PRESSURIZED TANK VERSION	OB1 PRESSURE CHANNEL RANGES				
	0 to 200 mbar (0 to 2.9 psi)	0 to 2,000 mbar (0 to 29 psi)	0 to 8,000 mbar (0 to 116 psi)	-900 to 1,000 mbar (-13 to 14.5 psi)	-900 to 6,000 mbar (-13 to 87 psi)
XXS	✓	*	*	*	*
XS	✓	✓	✓	✓	✓
S	✓	✓	✓	✓	✓
M	✓	✓	✓	✓	✓
L	✓	✓	**	✓	**
HP	✓	✓	✓	✓	✓

*not tested in these conditions

** The reservoir passed the pressure resistance tests in these conditions; nevertheless, Elveflow doesn't recommend using it as they are sensitive to mechanical damage

EPS PRESSURE SOURCE

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-ACCESSORIES/LABORATORY-PRESSURE-SOURCE/



A **COMPACT** AND **LIGHT** PRESSURE SOURCE



An **oil-free** pressure source to ease the integration in a laboratory environment thanks to its small footprint and integrated tank.

✓ **PORTABLE**

✓ **EASY-TO-USE**

UNIQUE PERFORMANCES

- > Positive pressure **2 bar**
- > Low noise level **<53 dB**
- > Small footprint **2kg**

APPLICATIONS

- > This pressurized air source is ideal to supply compressed air to a pressure regulator such as the OB1.
- > The steady pressure over 2000 mbar makes it the perfect complementary pressure supply for up to 2 channels 2 bar or 200 mbar OB1 pressure regulators.



OTHER PRESSURE GENERATOR: PRESSURIZED AIR SOURCE (KCP-230/120)



ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-ACCESSORIES/AIR-PRESSURE-GENERATOR/

A CLEAN PRESSURIZED AIR SOURCE

This **lubricated air compressor** is a powerful alternative to laboratory gas line supplies. The in-built 5 µm oil filter prevents microdroplets from entering into the instruments. In addition, anti-corrosion treatments of the receiver and long-life synthetic oil utilization makes this pressurized air source the most robust companion for **pressure-driven control** in laboratories.

TECHNICAL SPECIFICATIONS COMPARISON

KCP & EPS

		KCP-230 / KCP-120	PRESSURE SOURCE (EPS)
Performances	Max pressure	8 bar (120 psi)	3 bar (44 psi)
	Air flow rate (at operating pressure)	11 L/min	1.5 L/min (at 2 bar)
	Noise level	<35 dB	<53 dB
Mechanical specifications	Dimensions (without connectors, cm)	38.4 x 33.3 x 34.2	16.1 x 19.4 x 19.5
	Weight	18 Kg	2 Kg
	Pneumatic connection	6mm push-in	
	Internal receiver volume	4 L	350 mL
	Operating temperature	-	5-40 °C
	Operating humidity	-	Up to 80%
Electrical specifications	Input voltage range	-	24 V
	AC supply frequency	50-60 Hz	
	Power supply voltage	100-240 VAC	
	Max current consumption	0.9 A	1.5 A (typical: 0.8 A)
	Max power consumption	-	36 W

Non-contractual information, may be changed without notice.

EVS VACUUM SOURCE

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-ACCESSORIES/NOISELESS-VACUUM-SOURCE/



A COMPACT AND LIGHT VACUUM SOURCE



An **oil-free** vacuum source to ease the integration in a laboratory environment thanks to its small footprint and integrated tank.

✓ **PLUG&PLAY**

✓ **SMALL FOOTPRINT**

UNIQUE PERFORMANCES

- > Negative pressure **-850 mbar**
- > Low noise level **<51 dB**
- > Small footprint **1.4 Kg**

APPLICATIONS

- > This pressurized air source is ideal to supply vacuum to a pressure regulator such as the OB1.
- > The steady pressure of 2000 mbar makes it the perfect complementary vacuum supply for 0-200 mbar or 0-2000 mbar OB1 pressure regulators.



OTHER VACUUM SOURCE: VACUUM GENERATOR (KVP-230)



A HIGH EFFICIENCY VACUUM PUMP

This **high accuracy** microfluidic vacuum source generates negative pressure for microfluidic flow control without installation/connection of any instrument. The **anticorrosive coating** of the receiver ensures a long lifespan of the instruments.

ELVEFLOW.COM/MICROFLUIDIC-PRODUCTS/MICROFLUIDICS-ACCESSORIES/VACUUM-GENERATOR/

TECHNICAL SPECIFICATIONS COMPARISON

KVP & EVS

		KVP-230 / KVP-110	VACUUM SOURCE (EVS)
Performances	Vacuum pressure (relative)	-980 mbar (-15 psi)	-850 mbar (-13 psi)
	Vacuum pressure (absolute)	20 mbar (0.1 psi)	150 mbar (2.3 psi)
	Pumping speed	18 L/min	8 L/min at 0 bar
	Noise level	<42 dB	<53 dB
Mechanical specifications	Dimensions (without connectors, cm)	30 x 17 x 24	14 x 18 x 14
	Weight	3 Kg	1.4 Kg
	Pneumatic connection	6mm push-in	
	Internal receiver volume	-	250 mL
	Operating temperature	-	5-40 °C
	Operating humidity	-	Up to 80%
Electrical specifications	Input voltage range	-	24 V
	AC supply frequency	-	50-60 Hz
	Power supply voltage	100-240 vac	
	Max current consumption	-	1.5 A (typical: 0.8 A)
	Max power consumption	140 W	36 W

Non-contractual information, may be changed without notice.

PLUG & PLAY MICROFLUIDICS

GENERAL INFORMATION

contact@elveflow.com

+33(0).184.163.807

www.elveflow.com

ELVESYS – Microfluidics innovation center

172 rue de Charonne
75011 Paris, FRANCE

**ELVE
FLOW**  an **ELVESYS** brand